

# WAVELENGTH DISPERSIVE SPECTROMETERS: LARGE-SCALE-FACILITY APPLICATIONS



<http://www.xraylab.fi/>

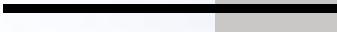
Simo Huotari  
Department of Physics  
University of Helsinki, Finland



University of Helsinki  
Est. 1640

# WIDE RANGE OF APPLICATIONS

Compton spectroscopy a few/several eV 

hi-res x-ray emission spectroscopy (sub-)eV 

resonant inelastic x-ray scattering,  
crystal field and magnetic excitations <100 meV 

phonons in crystals, molecular vibrations ~1 meV 

vibrational dynamics in  
disordered systems ~0.1 meV 

Ultra-high-resolution spectrographs <100  $\mu$ eV 

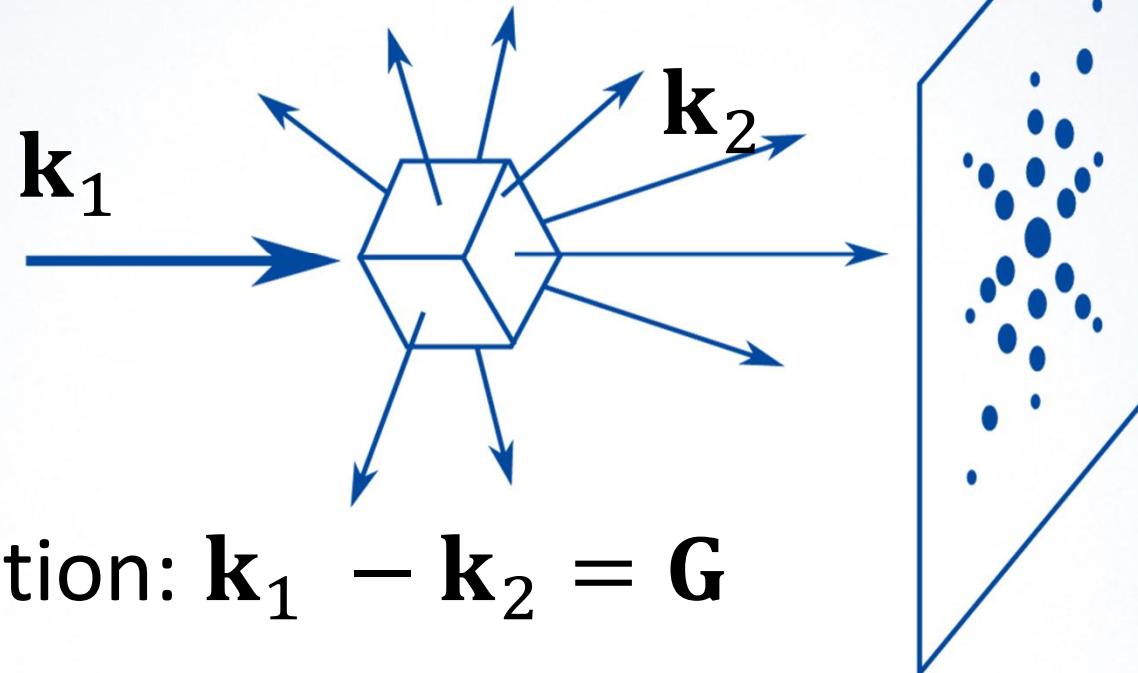
Yu. Shvyd'ko, S. Stoupin, K. Mundboth,  
and J-H. Kim, Phys. Rev. A 87 (2013) 043835

Need of a eV to sub-eV energy resolution  
for the emitted/scattered radiation

No x-ray detector capable of that

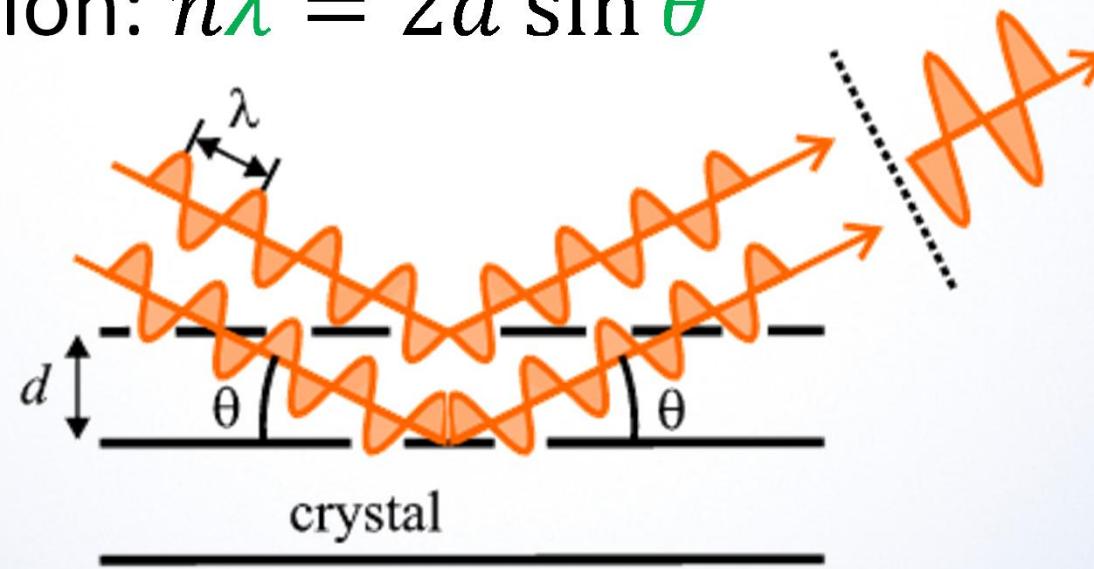
⇒ crystal x-ray optics

# HISTORY



Laue equation:  $\mathbf{k}_1 - \mathbf{k}_2 = \mathbf{G}$

Bragg equation:  $n\lambda = 2d \sin \theta$

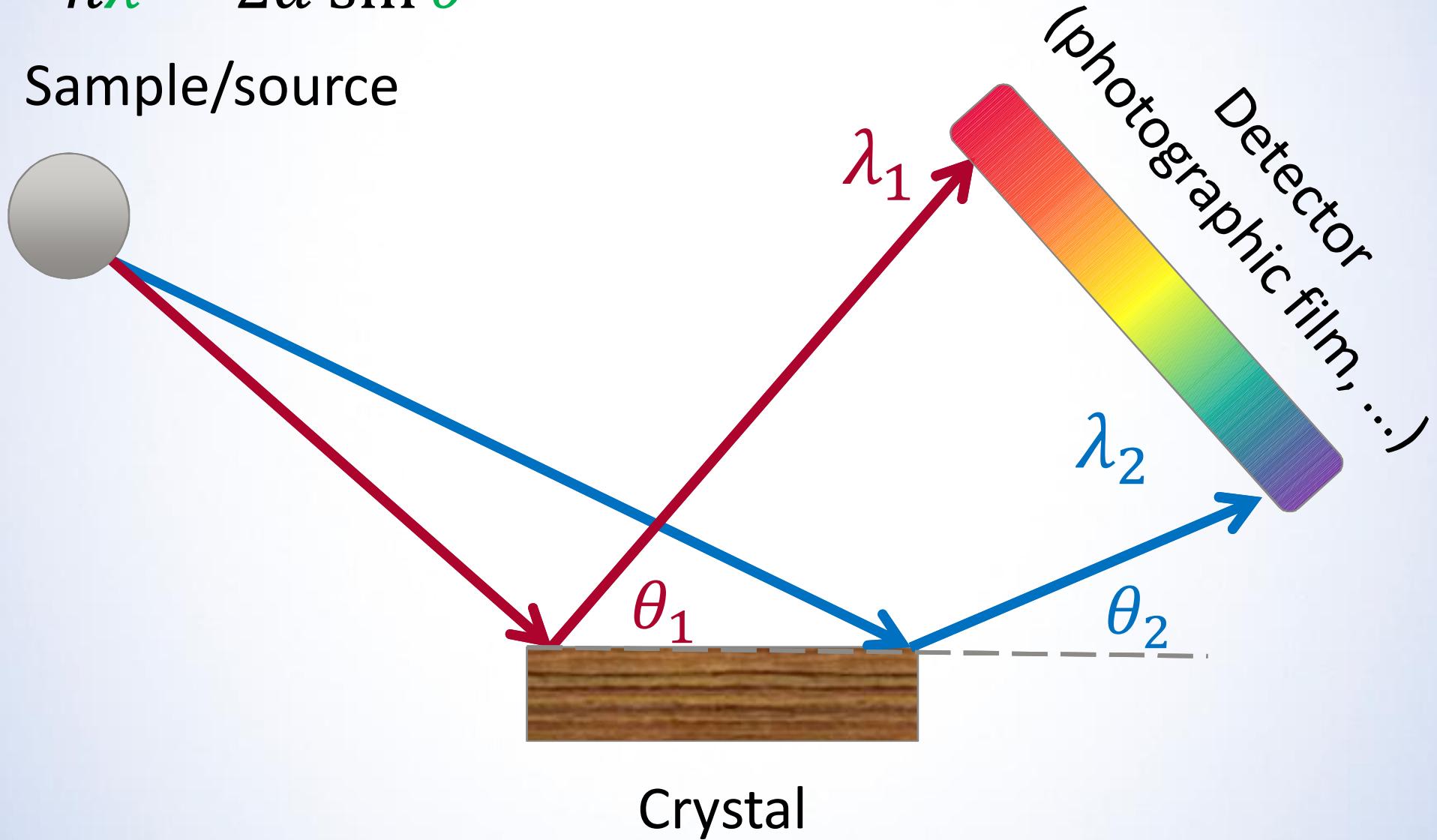


# EARLY SPECTROGRAPHS (1920-)

Bragg, Seeman, ...

$$n\lambda = 2d \sin \theta$$

Sample/source

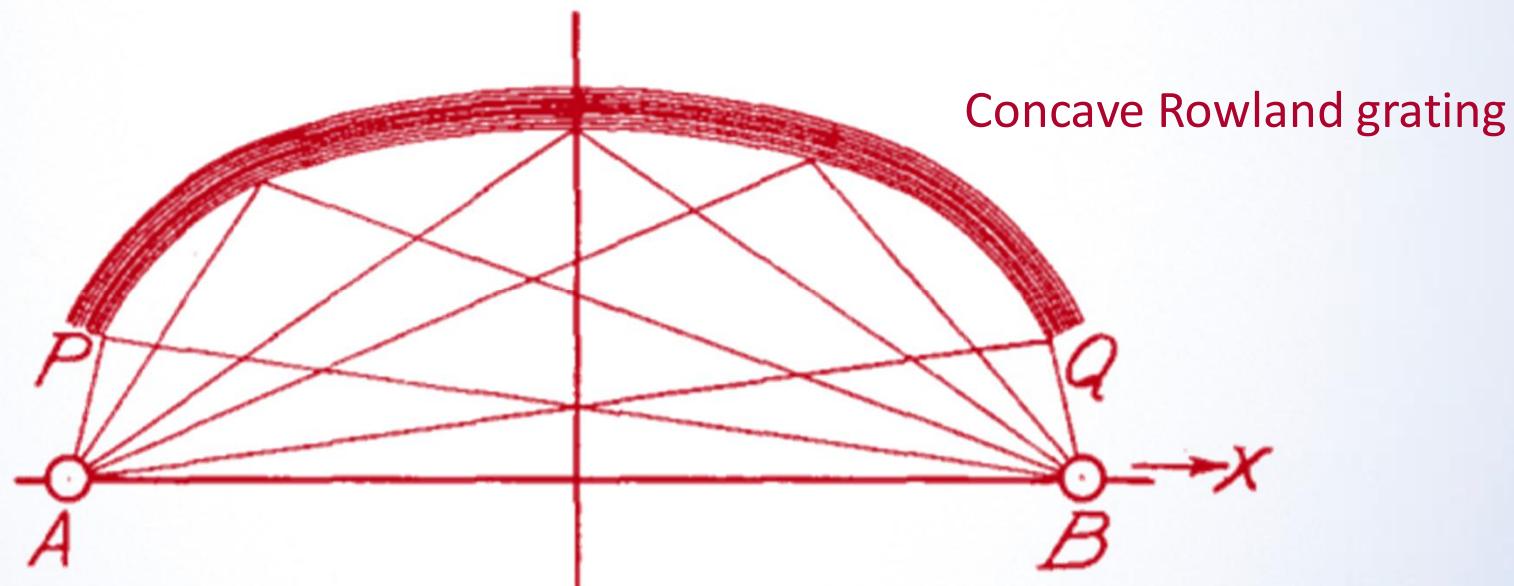


# THE MULTIPLE CRYSTAL X-RAY SPECTROGRAPH

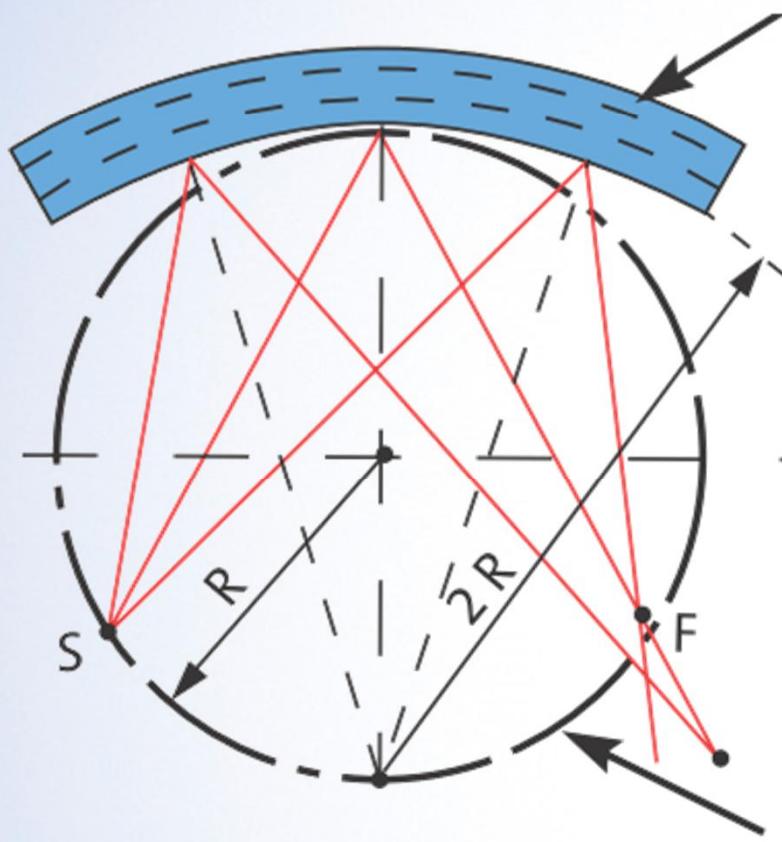
By JESSE W. M. DUMOND AND HARRY A. KIRKPATRICK

## ABSTRACT

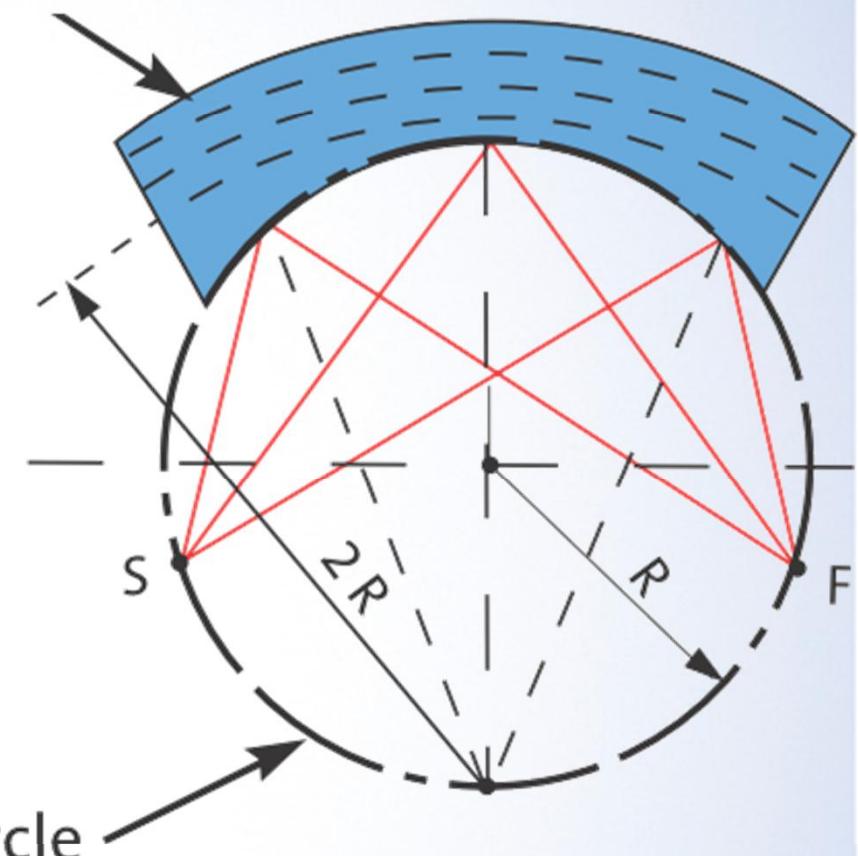
The need for improvements in scattered x-ray spectroscopic technique along the lines of increased intensity and contrast is discussed and a new instrument composed of fifty small units, each a Seeman Spectrograph in itself cooperating to form a single spectrogram, is described in detail. The technique of adjusting the instrument is also described.



## Crystal lattice planes



Semifocusing  
Johann curvature



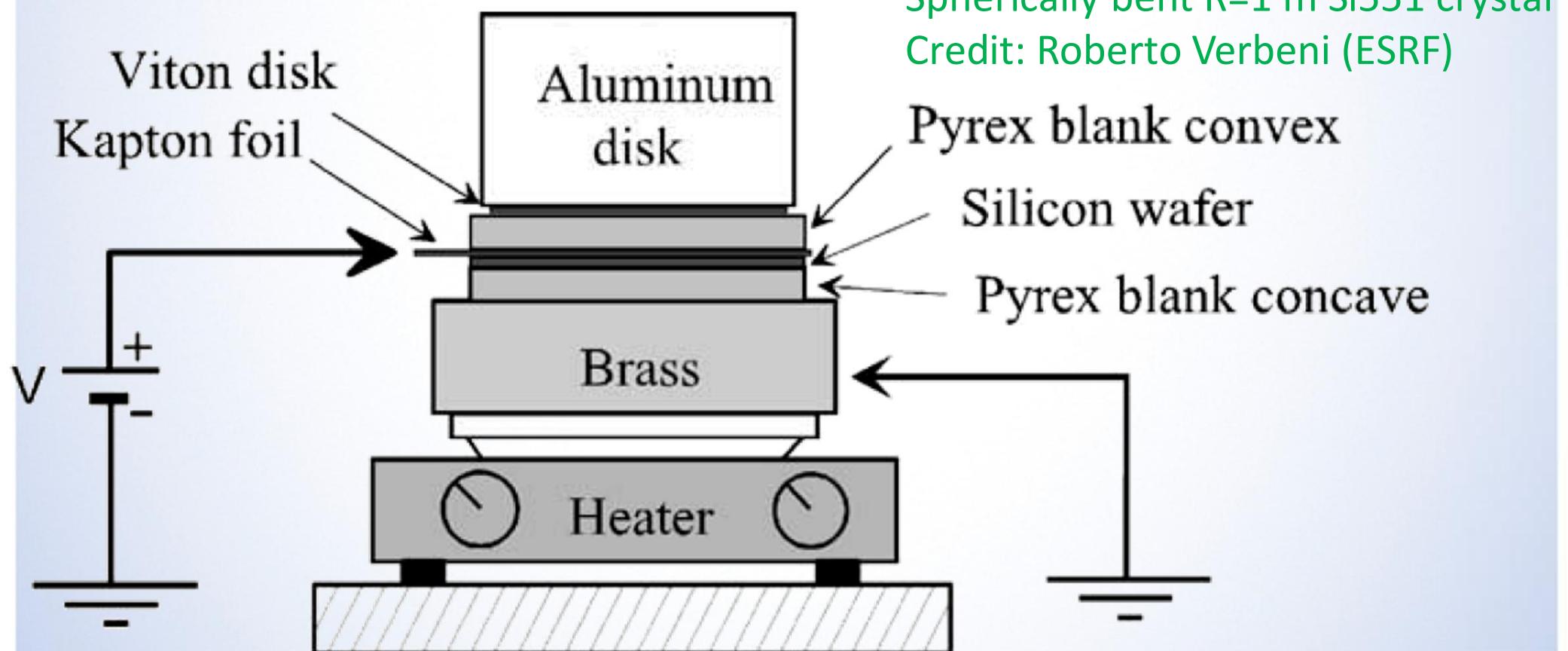
Single machining  
Johansson curvature  
(Theoretically exact focusing)

## POINT-BY-POINT SCANNING OF SPECTRA

Figure courtesy of Saint-Gobain crystals

# ANODIC BONDING TO A CURVED GLASS SUBSTRATE

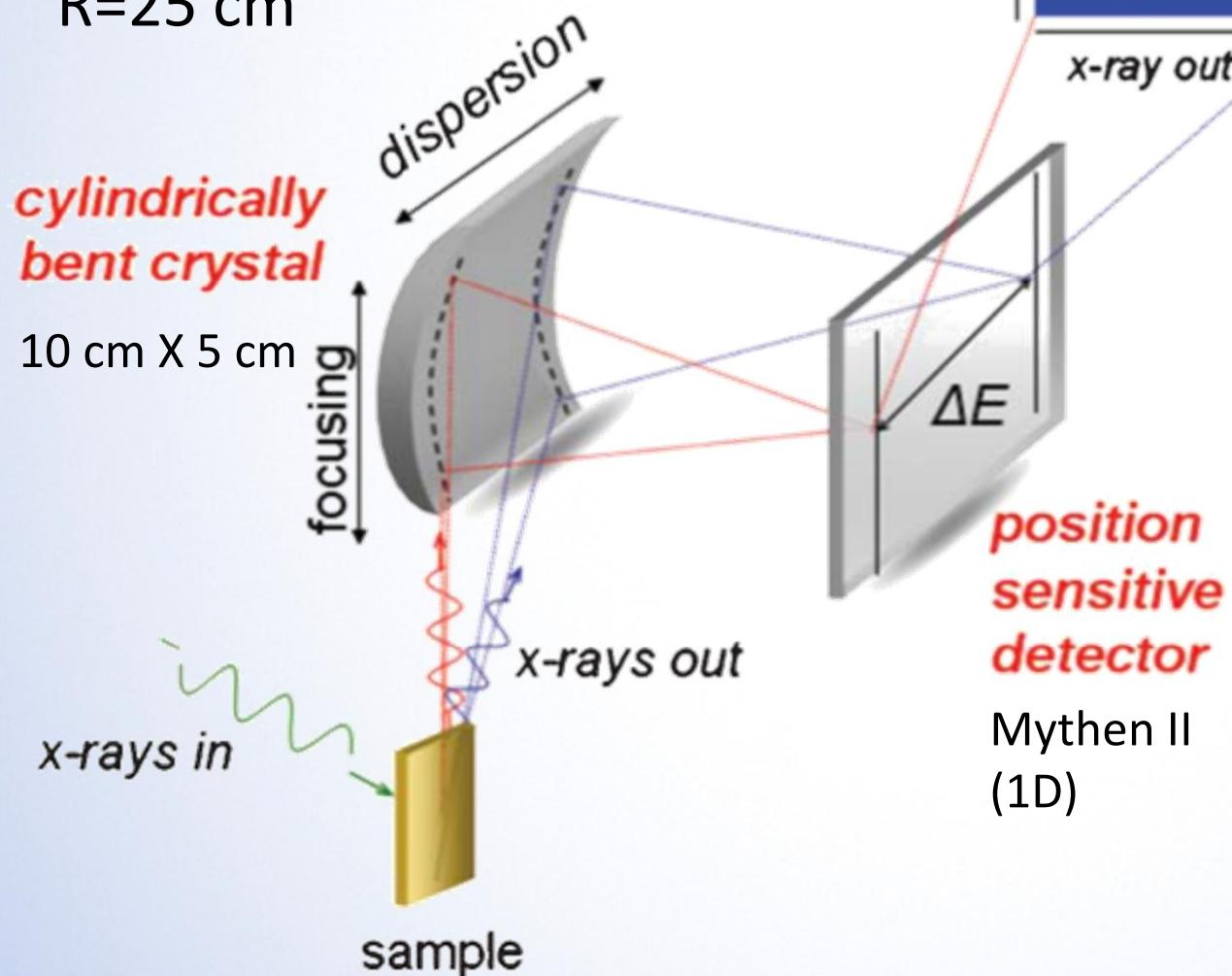
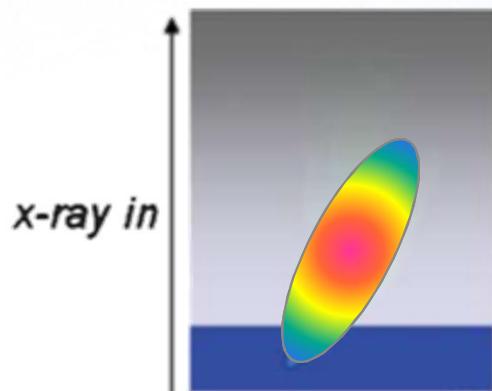
Verbeni et al. Journal of Physics and Chemistry  
of Solids 66 (2005) 2299–2305



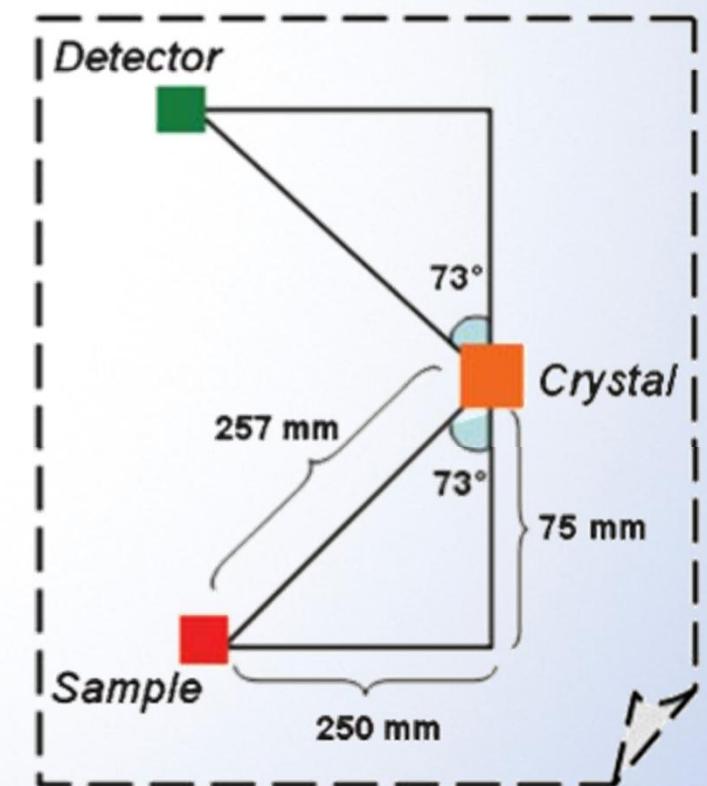
# VON HAMOS GEOMETRY

Jacinto Sá et al., RSC Adv.  
(2013) 3, 12043

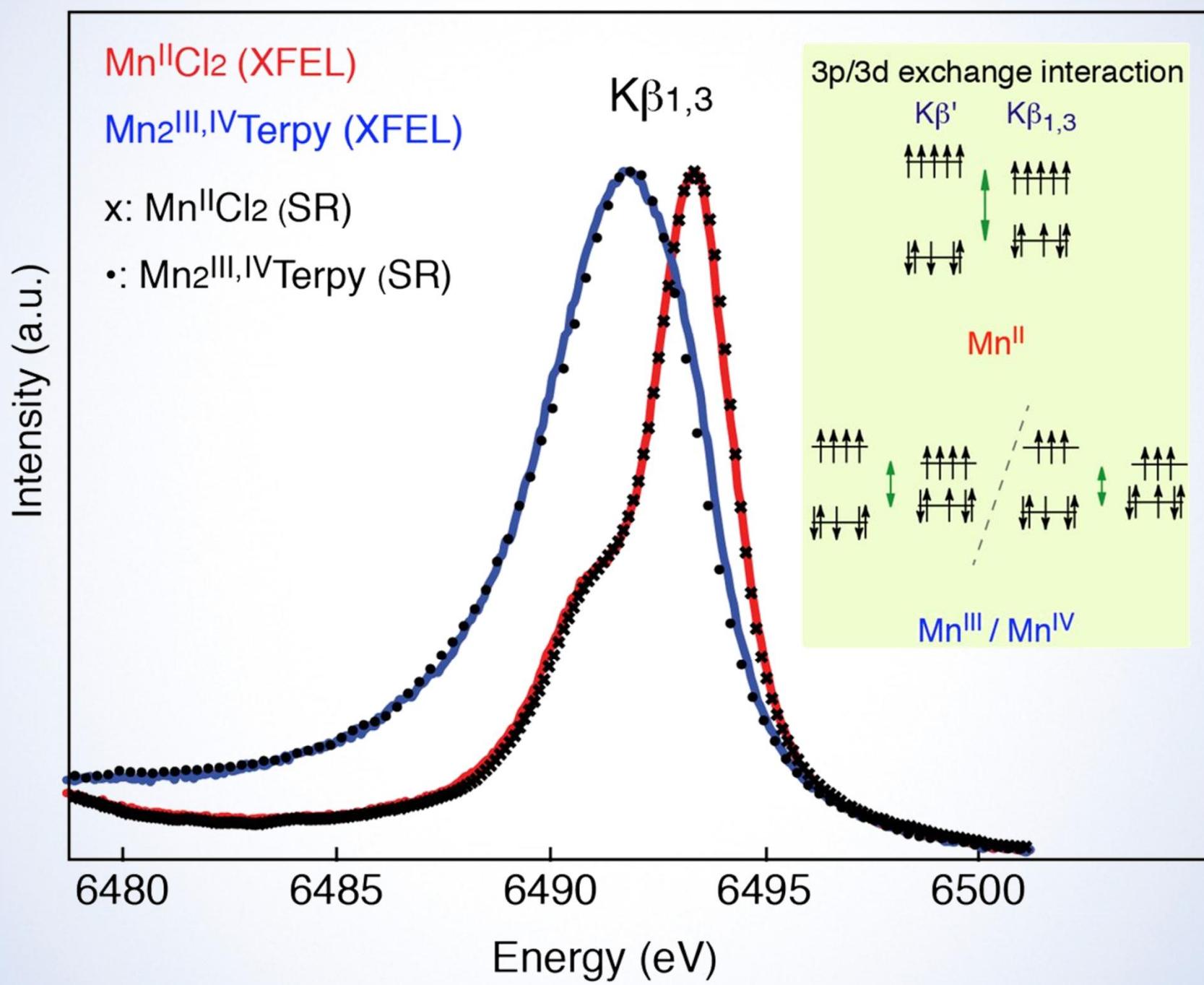
Ge(660) crystal,  
R=25 cm



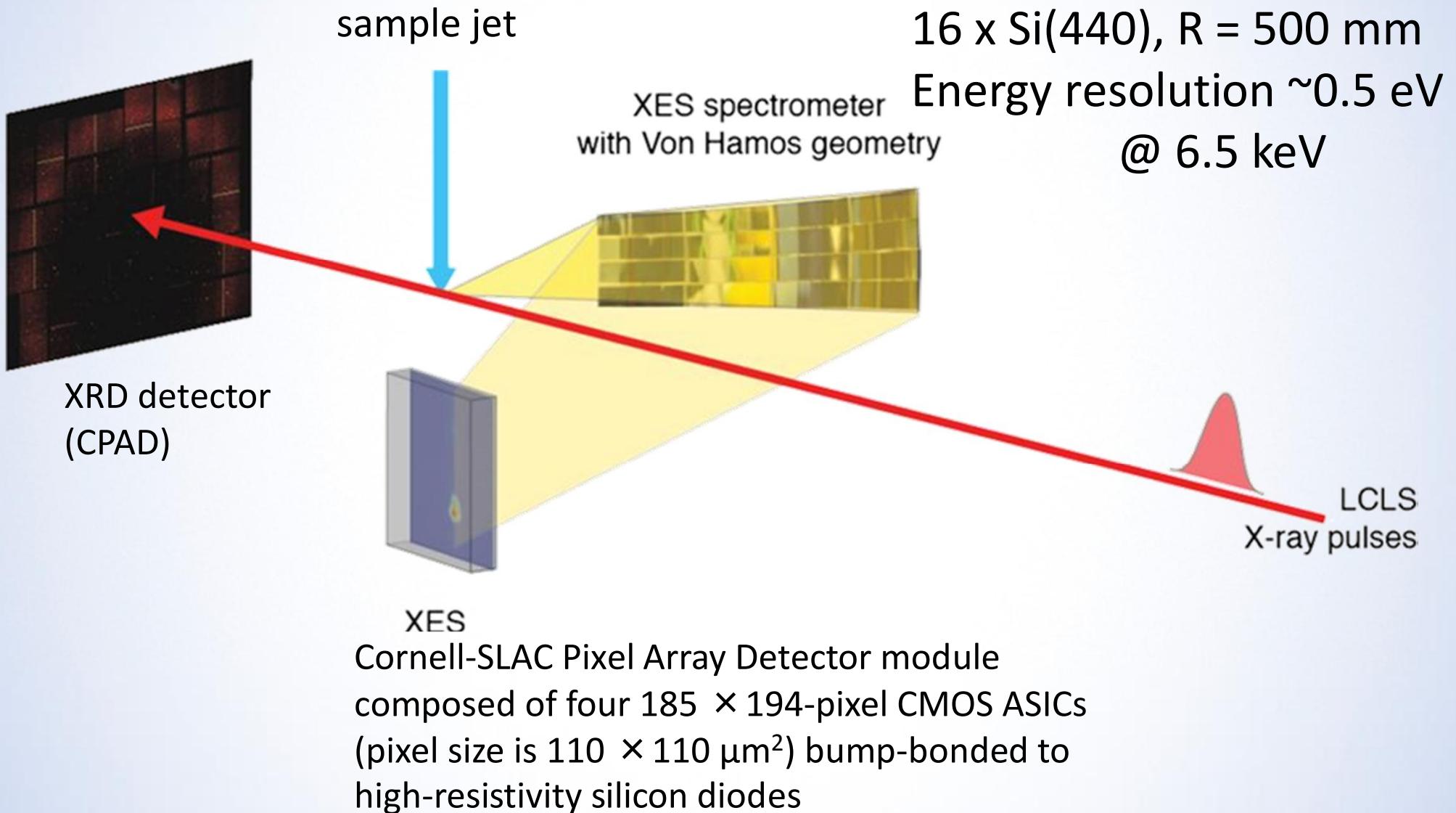
Example:  
SuperXAS @ SLS  
Energy  
resolution  
~1 eV @ 10 keV



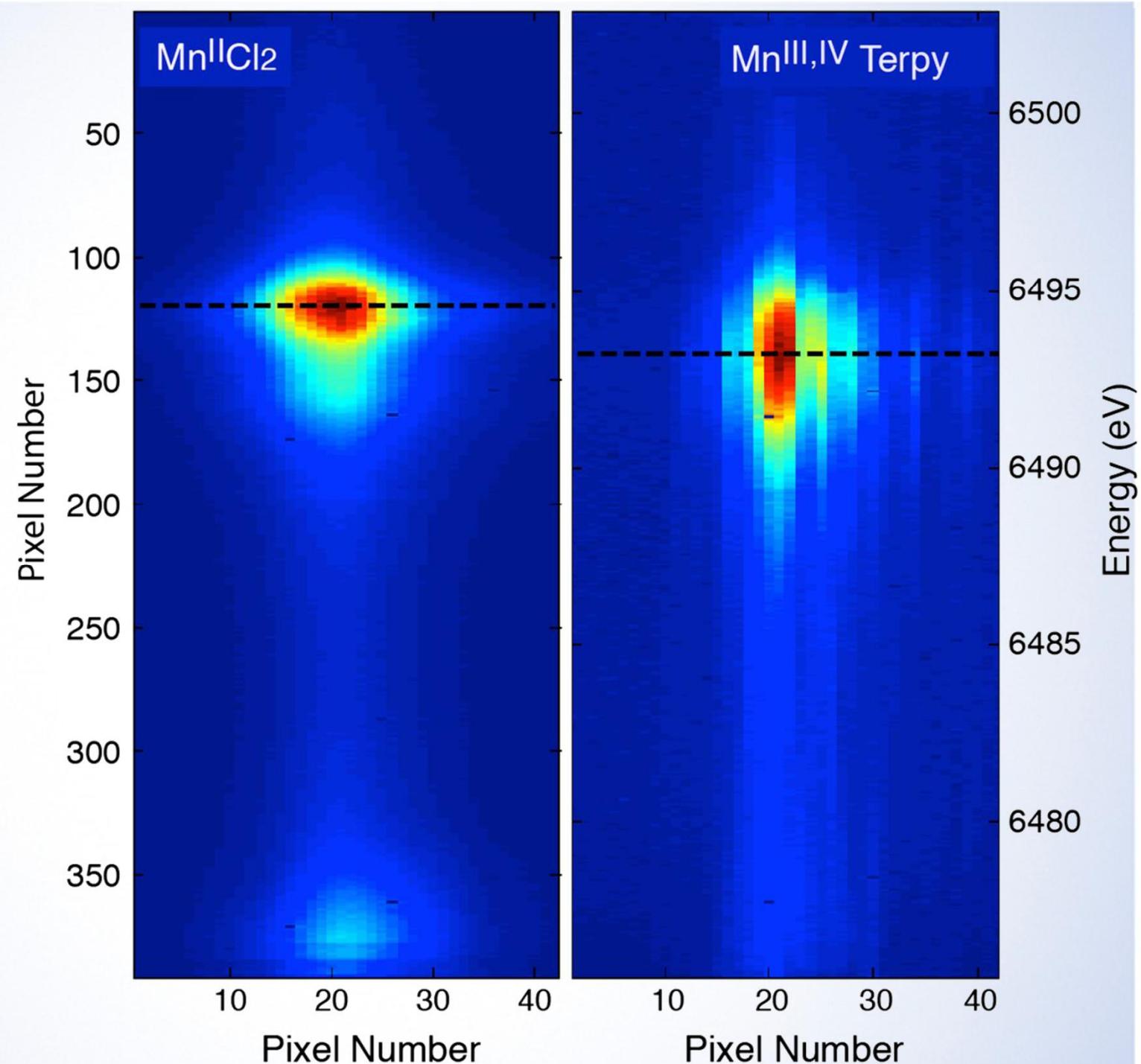
## CXI @ LCLS von Hamos



# VON HAMOS @ LCLS (CXI)



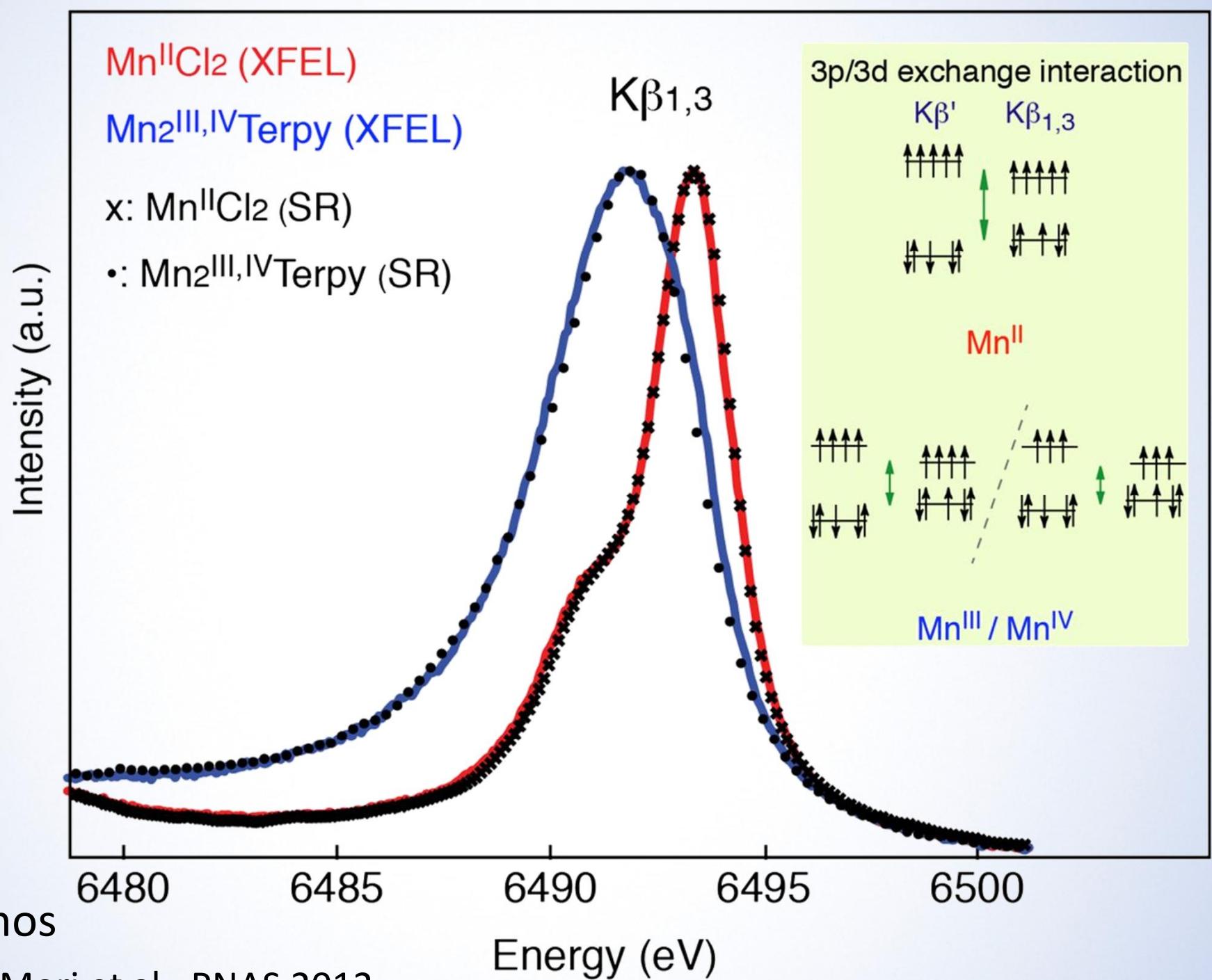
Cornell-SLAC  
Pixel Array  
Detector  
module  
composed of  
four 185  
 $\times$  194-pixel  
CMOS ASICs  
(pixel size is  
110  $\times$  110  
 $\mu\text{m}^2$ ) bump-  
bonded to  
high-resistivity  
silicon diodes



LCLS

von Hamos

R. Alonso Mori et al., PNAS 2012



# VON HAMOS AT EUROPEAN XFEL

## FXE instrument / Christian Bressler et al.

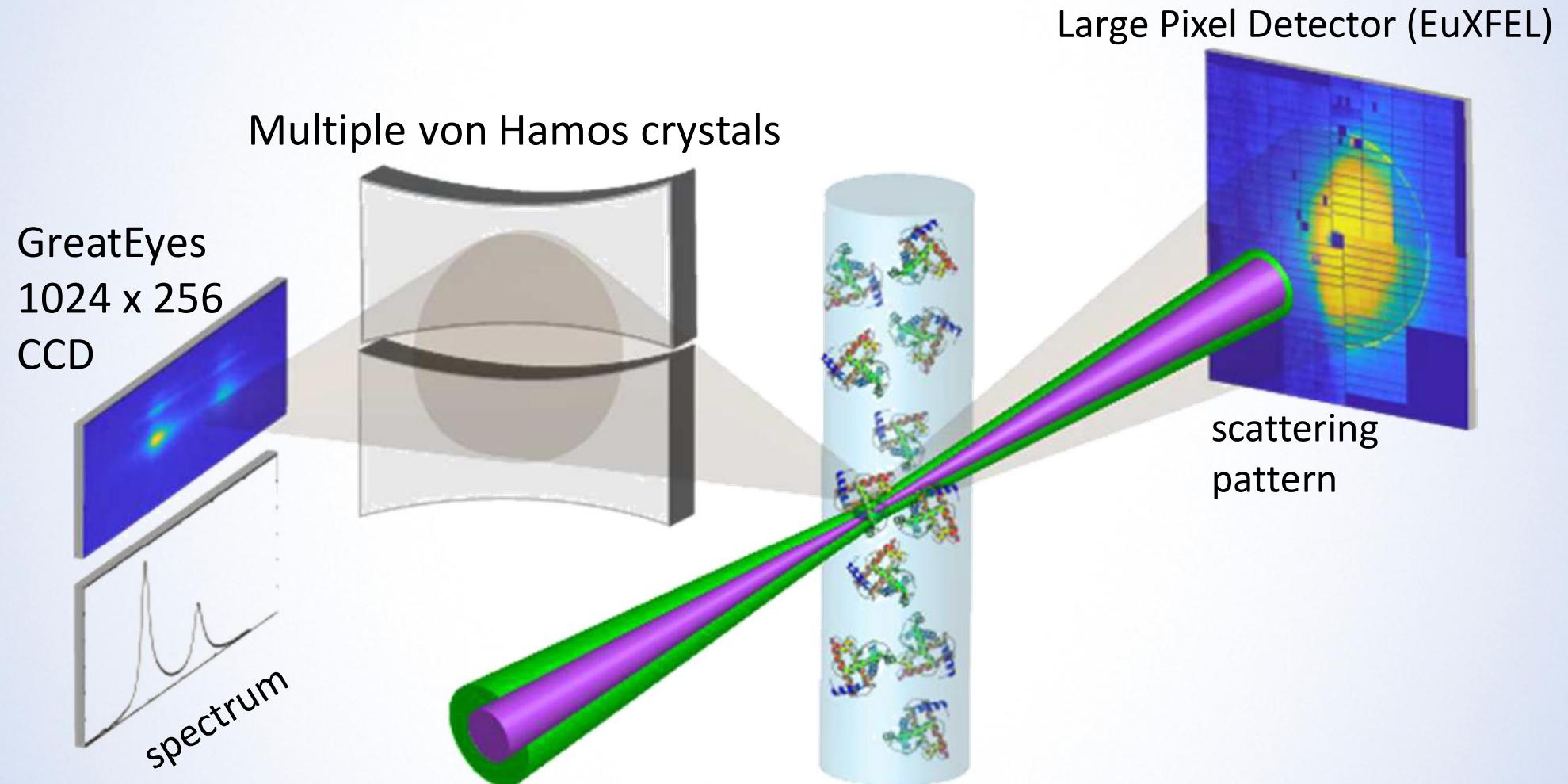
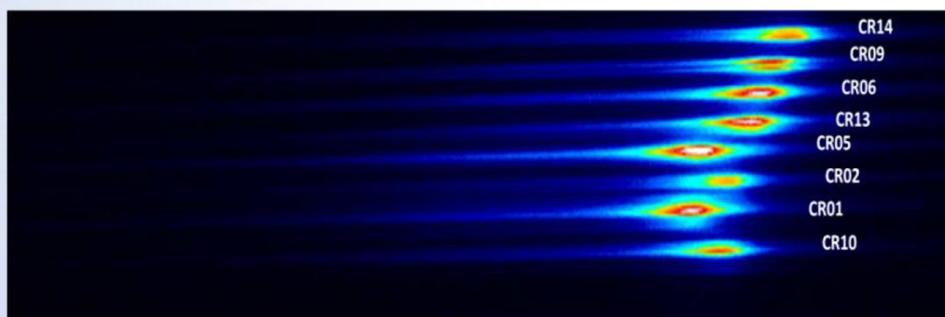
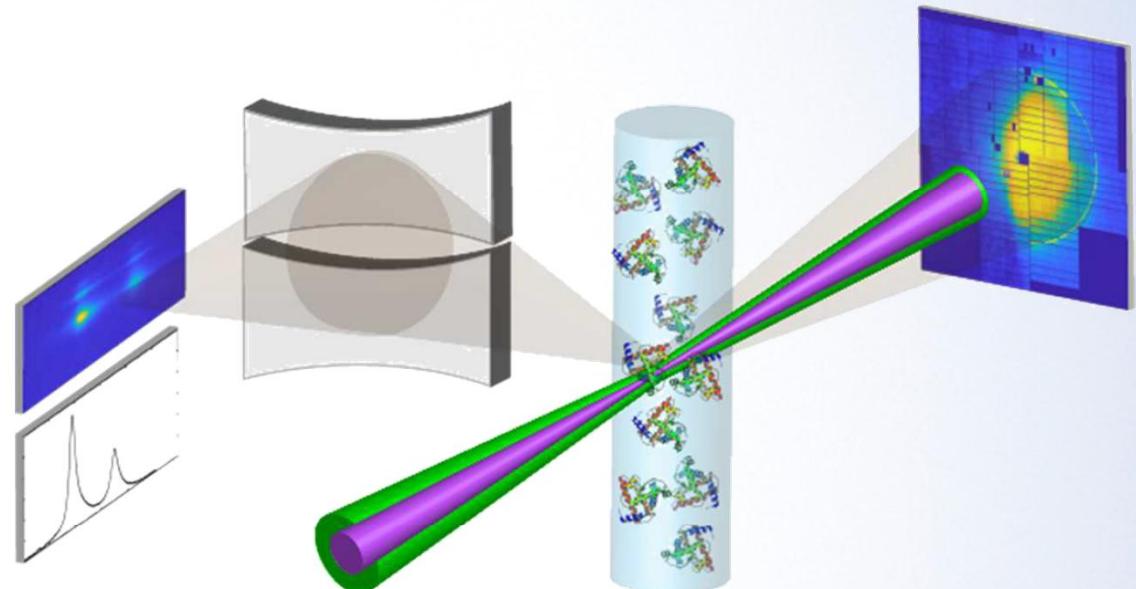
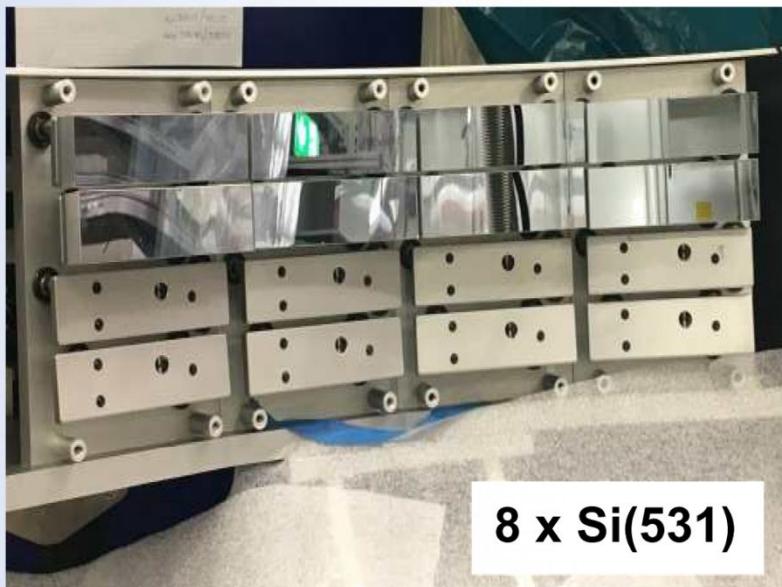


Figure courtesy of Christian Bressler, European XFEL, shared for this occasion

# VON HAMOS AT EUROPEAN XFEL

FXE instrument / Christian Bressler et al.

30 bunches, 9.3 keV, ~100uJ/pulse,  
focused to ~20 um

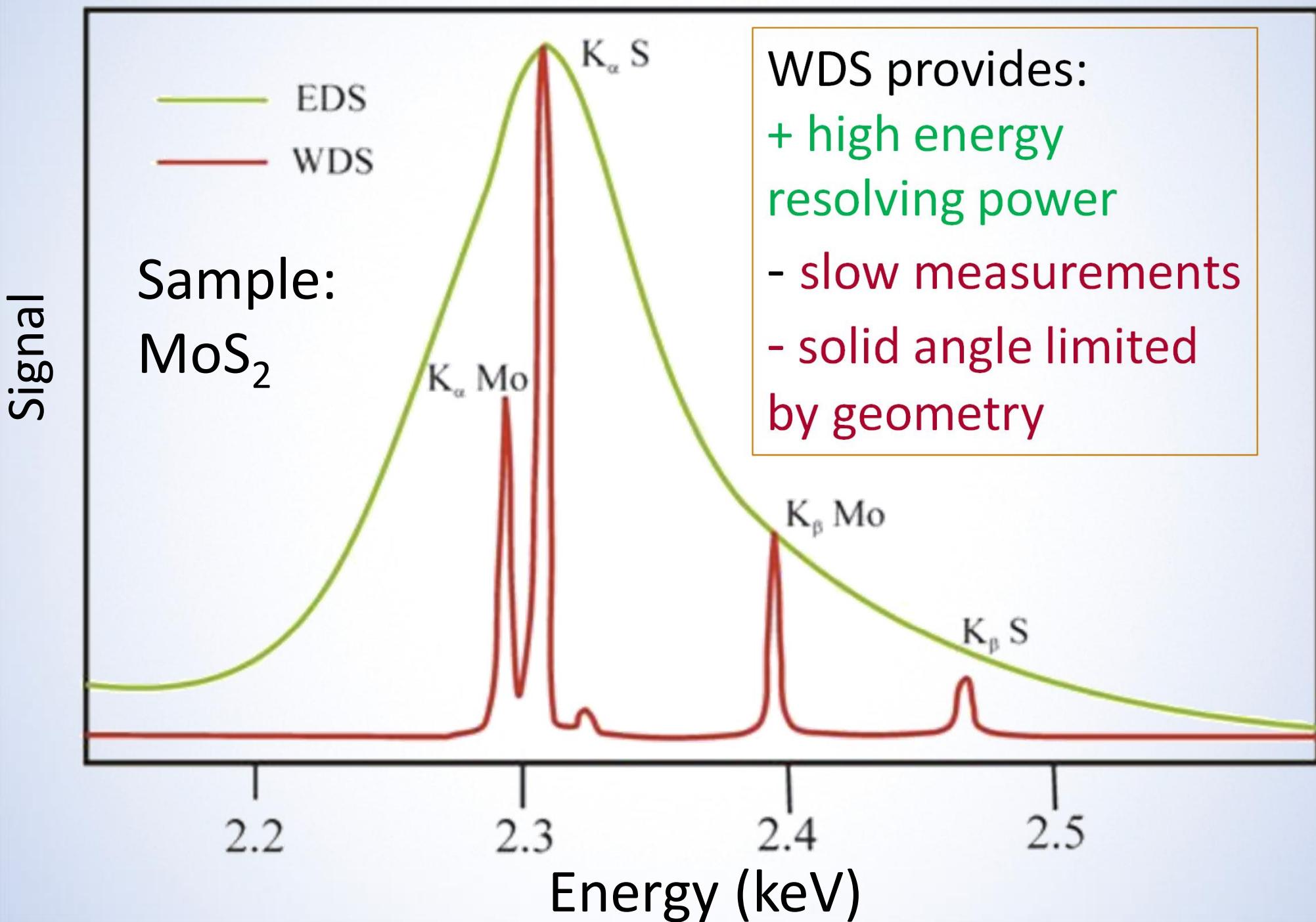


GreatEyes CCD detector

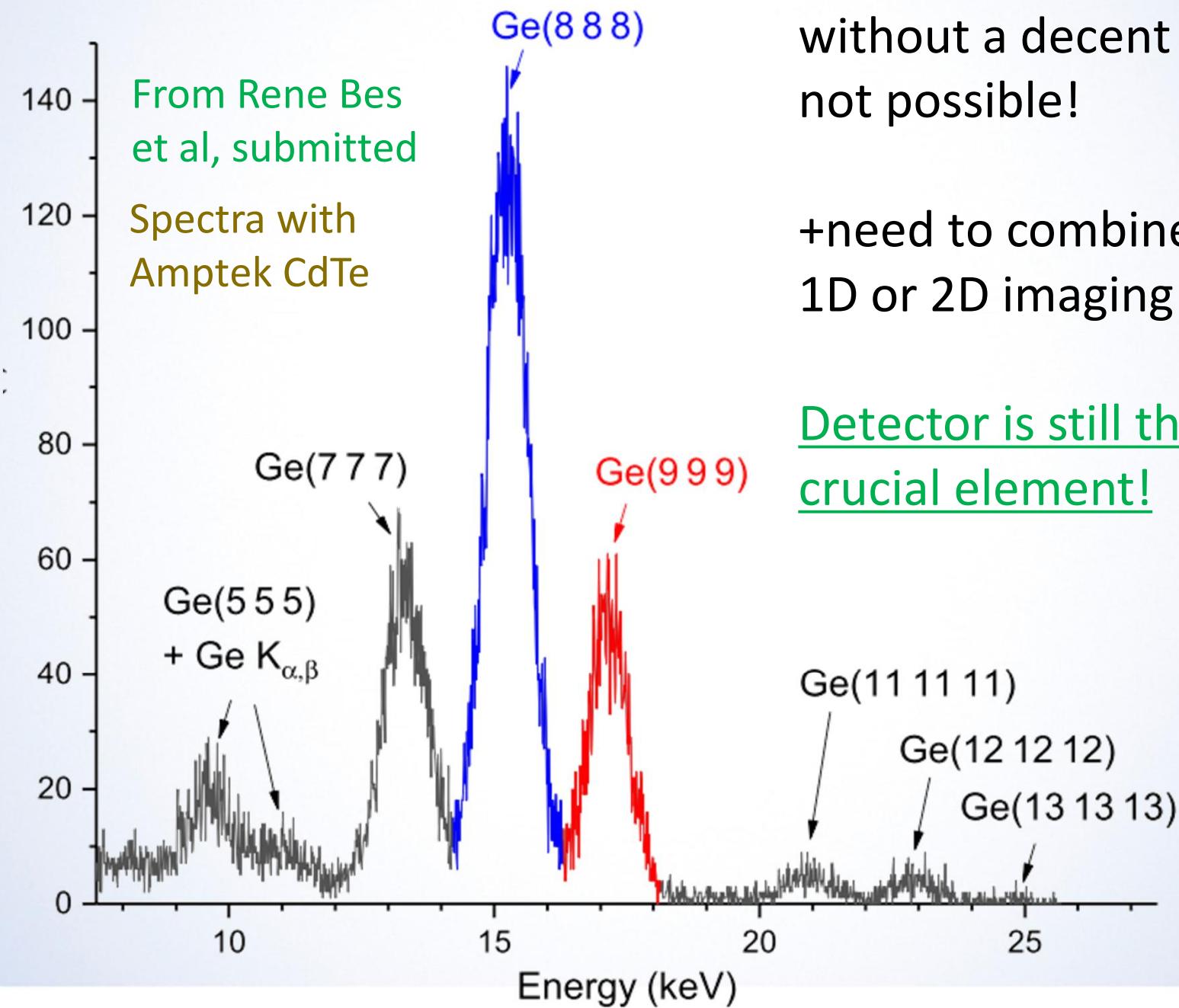
European XFEL

Slide courtesy of Christian Bressler,  
European XFEL, shared for this occasion

## Comparative Resolution



# High resolution, yes, but how about harmonic rejection?



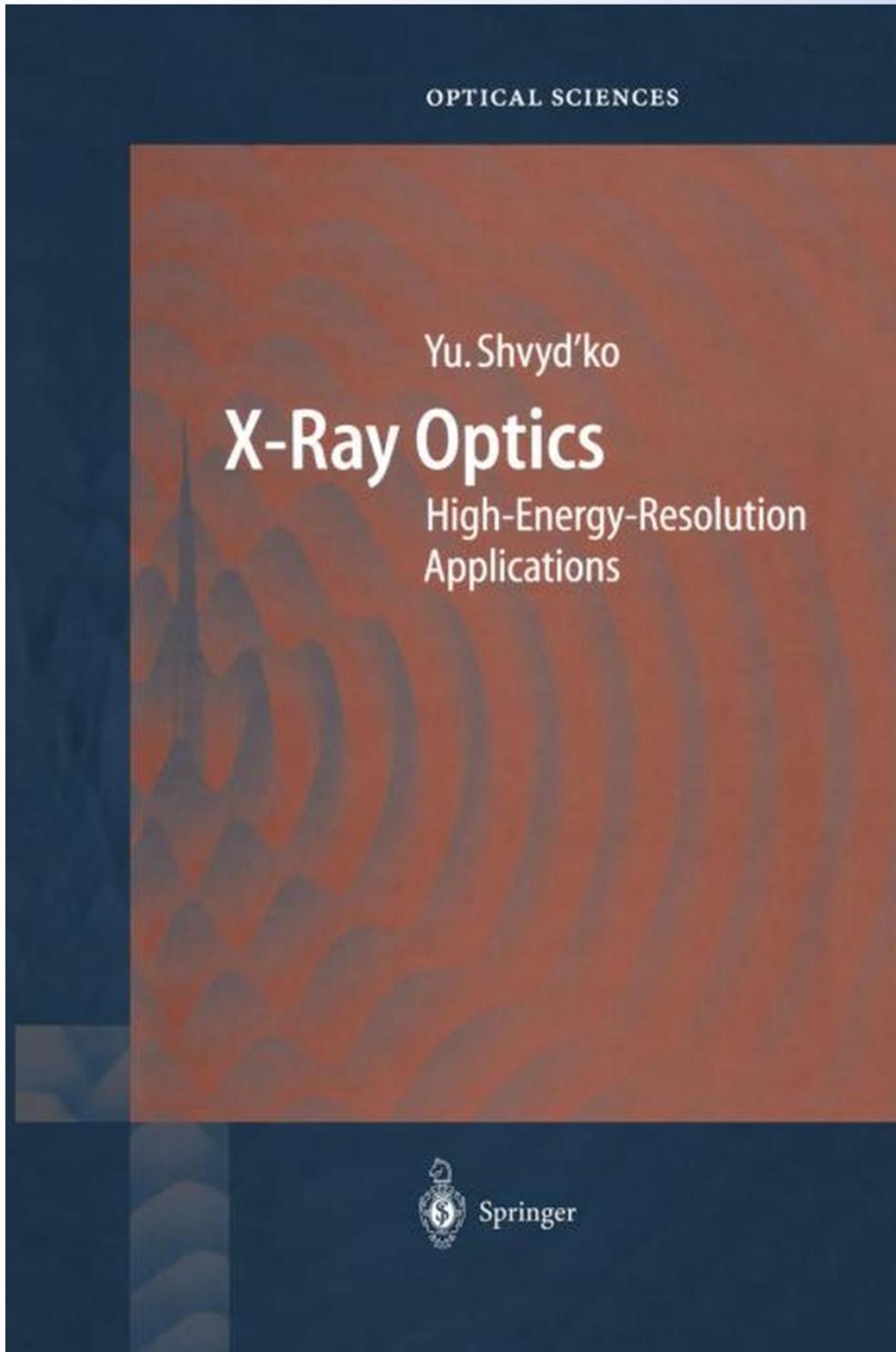
Picking up Ge(999)  
reflection from this mess  
without a decent EDS...  
not possible!

+need to combine with  
1D or 2D imaging capability

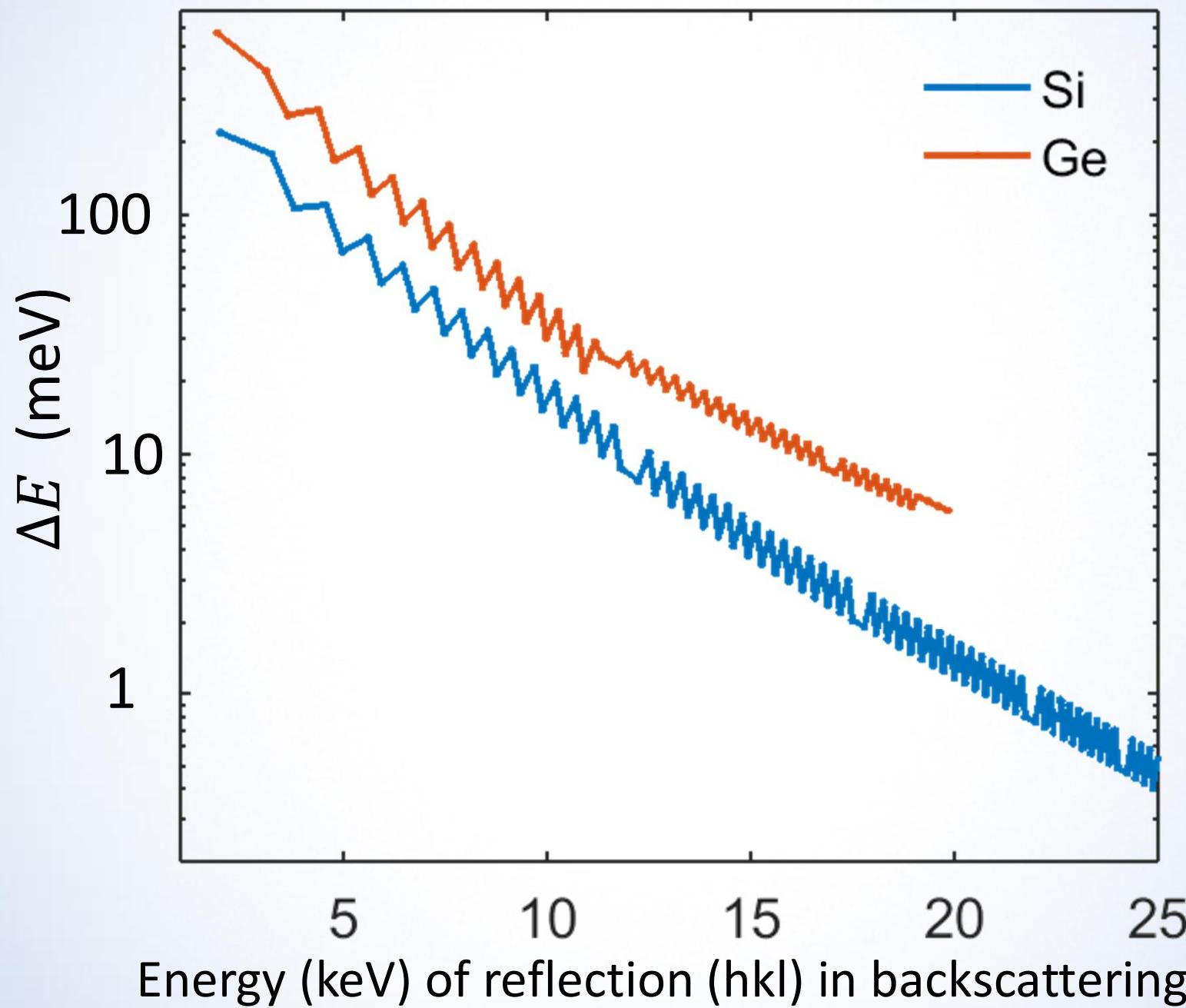
Detector is still the most  
crucial element!

# What determines the energy resolution?

- finite source size  $x$   
$$\Delta E/E = x/R \cot \theta$$
- crystal properties
  - Darwin width for flat crystals
  - Bending causes elastic stresses,  
$$\Delta E \propto d/R$$

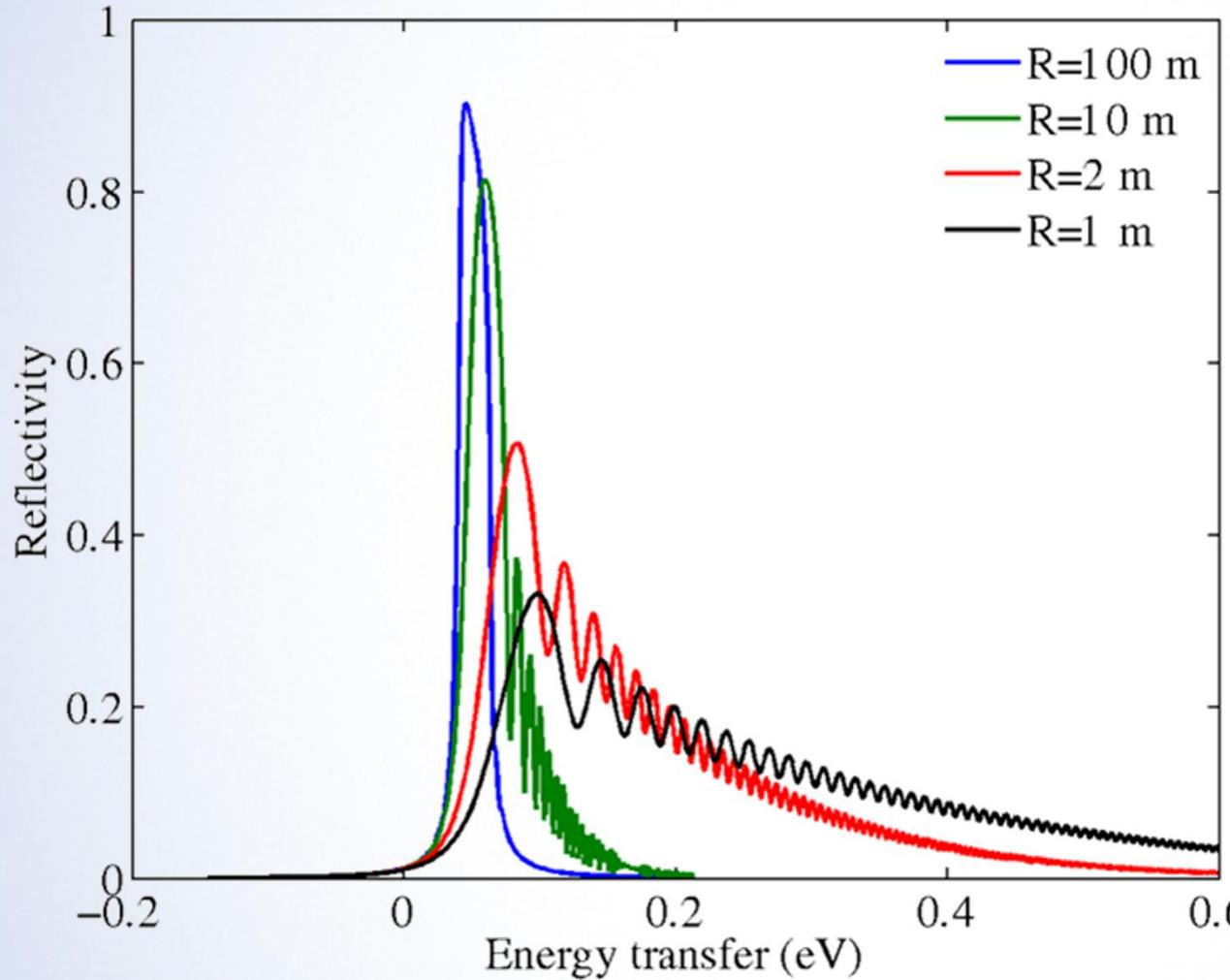


# ULTIMATE ENERGY RESOLUTION / PERFECT CRYSTAL



# Elastic bending $\Rightarrow$ strain

Si(660) reflectivity curves near backscattering,  $\theta \approx 88^\circ$



$$\frac{\Delta E}{E} \approx \frac{d}{R} (\cot^2 \theta - \nu)$$

$\nu$  = Poisson ratio

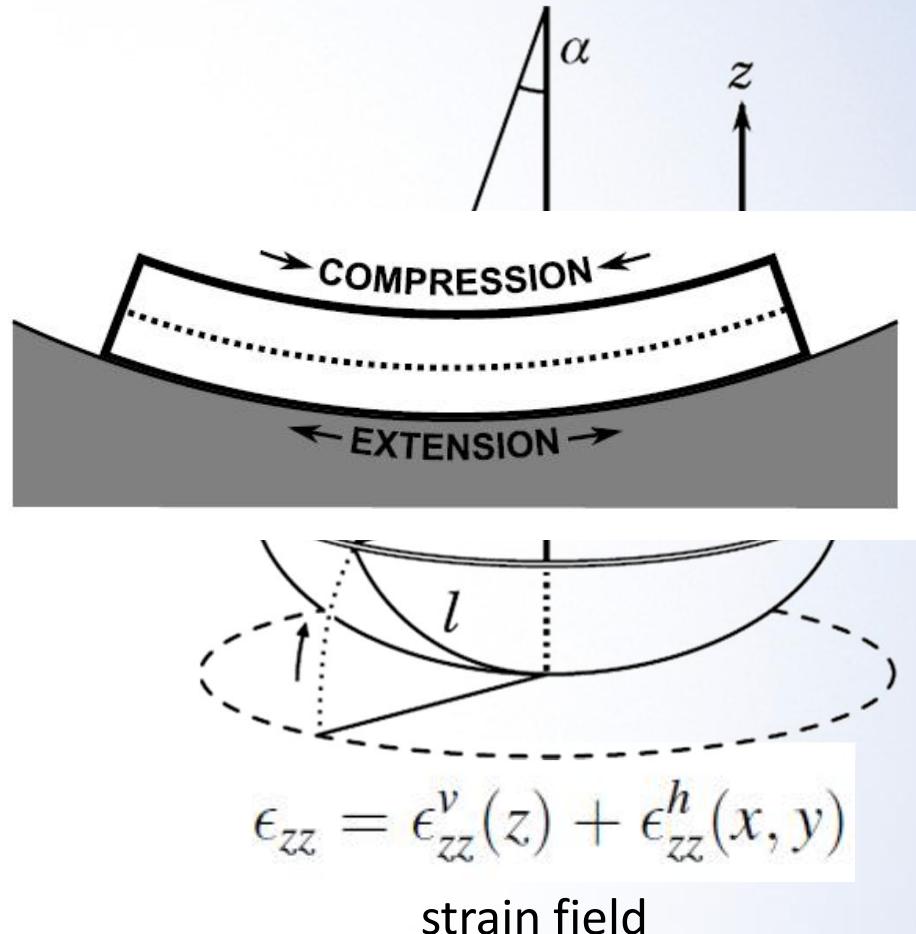


Taupin (1964), Takagi (1962,1969)

Implementation in XOP

R=1 m Si spherically bent crystal, R. Verbeni (ESRF)

- Diffraction curve for a macroscopic elastically bent crystal – both with finite area and finite thickness
- Spherical bending causes angular compression → contribution to strain proportional to  $(r/R)^2$



$$\epsilon_{zz}(r, \phi, z) = \frac{C_{31} + C_{32}}{C_{33}} \frac{z}{R} - \frac{r^2}{6R^2} \frac{S_{31}(\phi) + 3S_{32}(\phi)}{\langle S_{21}(\phi) \rangle + 3 \langle S_{22}(\phi) \rangle}$$

Ari-Pekka Honkanen et al.,  
J. Synchrotron Radiat. 11, 762 (2014)  
J. Appl. Cryst. 49, 1284 (2016)

$C_{ij}$ =stiffness tensor  
 $S_{ij}$ =compliance tensor

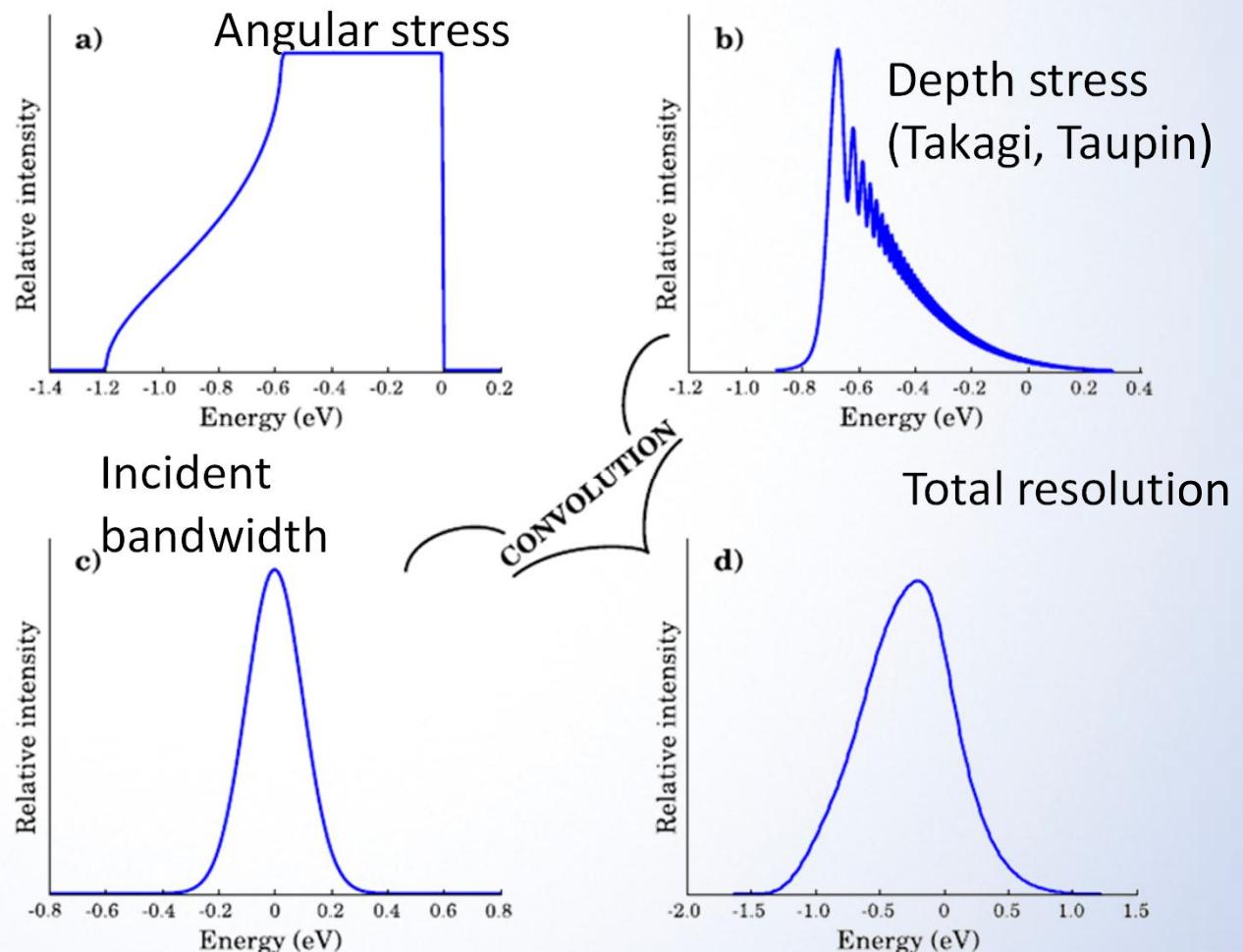
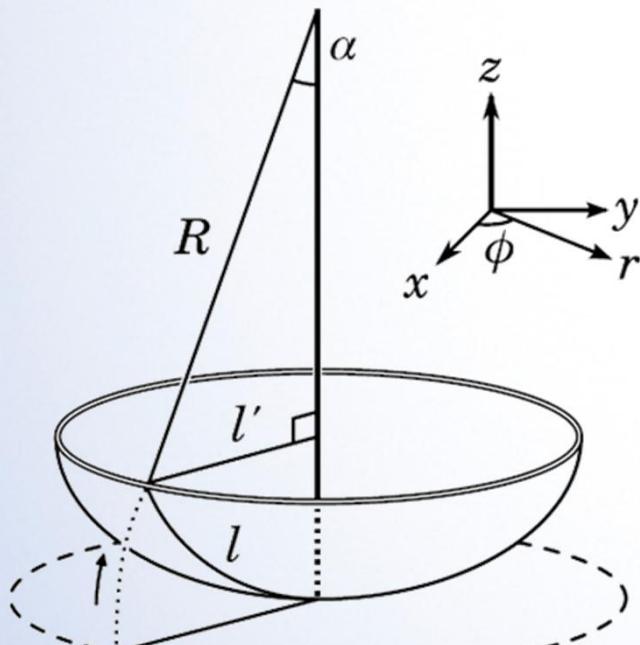
# Study on the reflectivity properties of spherically bent analyser crystals

J. Synchr. Rad. 21, 762 (2014)

Ari-Pekka Honkanen,<sup>a</sup> Roberto Verbeni,<sup>b</sup> Laura Simonelli,<sup>b</sup> Marco Moretti Sala,<sup>b</sup> Giulio Monaco<sup>b</sup> and Simo Huotari<sup>a</sup>

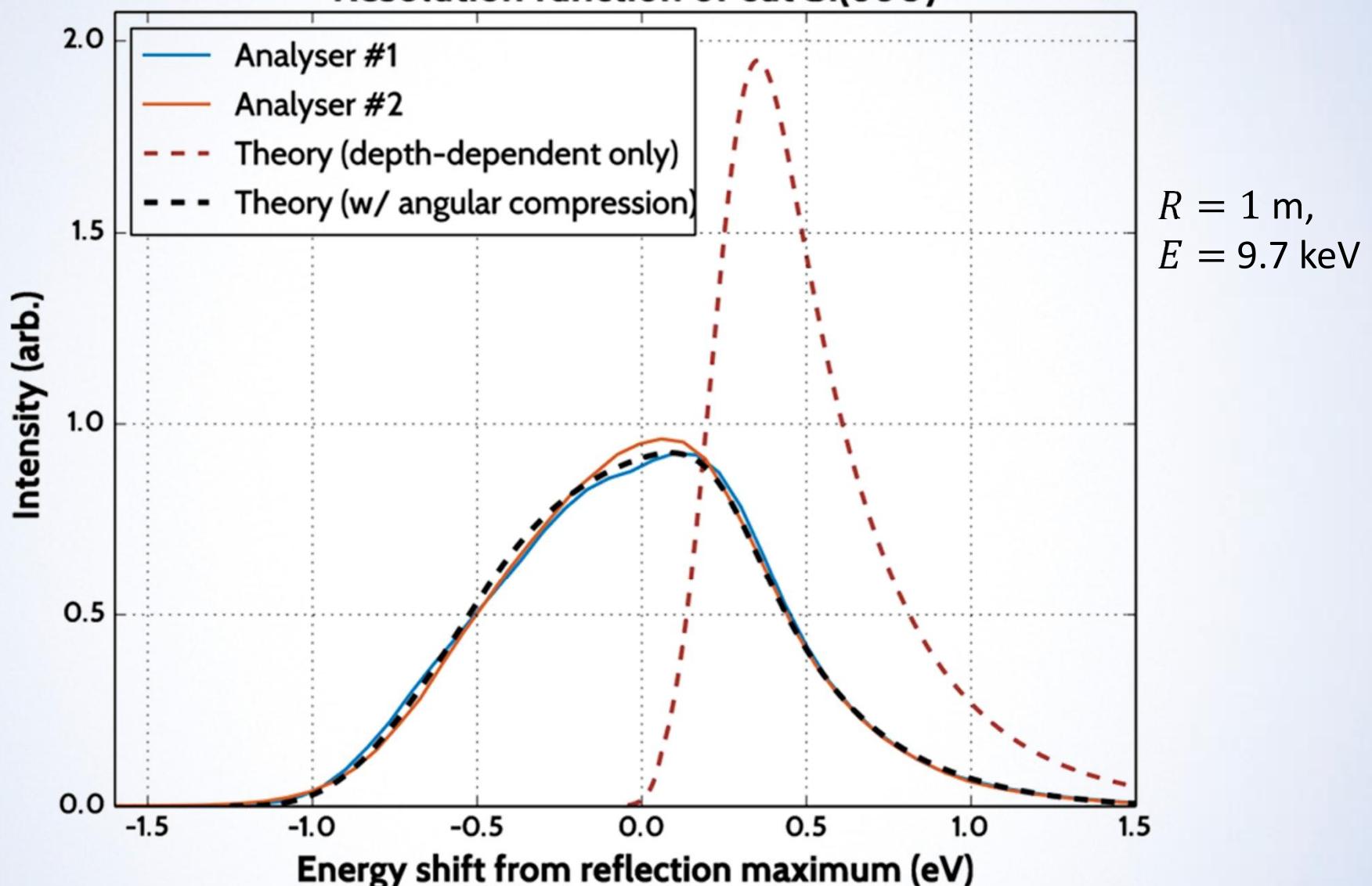
Department of Physics, P. O. Box 64, FI-00014 Helsinki, Finland, and <sup>b</sup>European Synchrotron Radiation Facility, B. P. 220, F-38043 Grenoble cedex, France

Simulation for 9.7 keV, Si(660),  
R=1 m 4-inch wafer (100 mm)



# Bent crystal diffraction

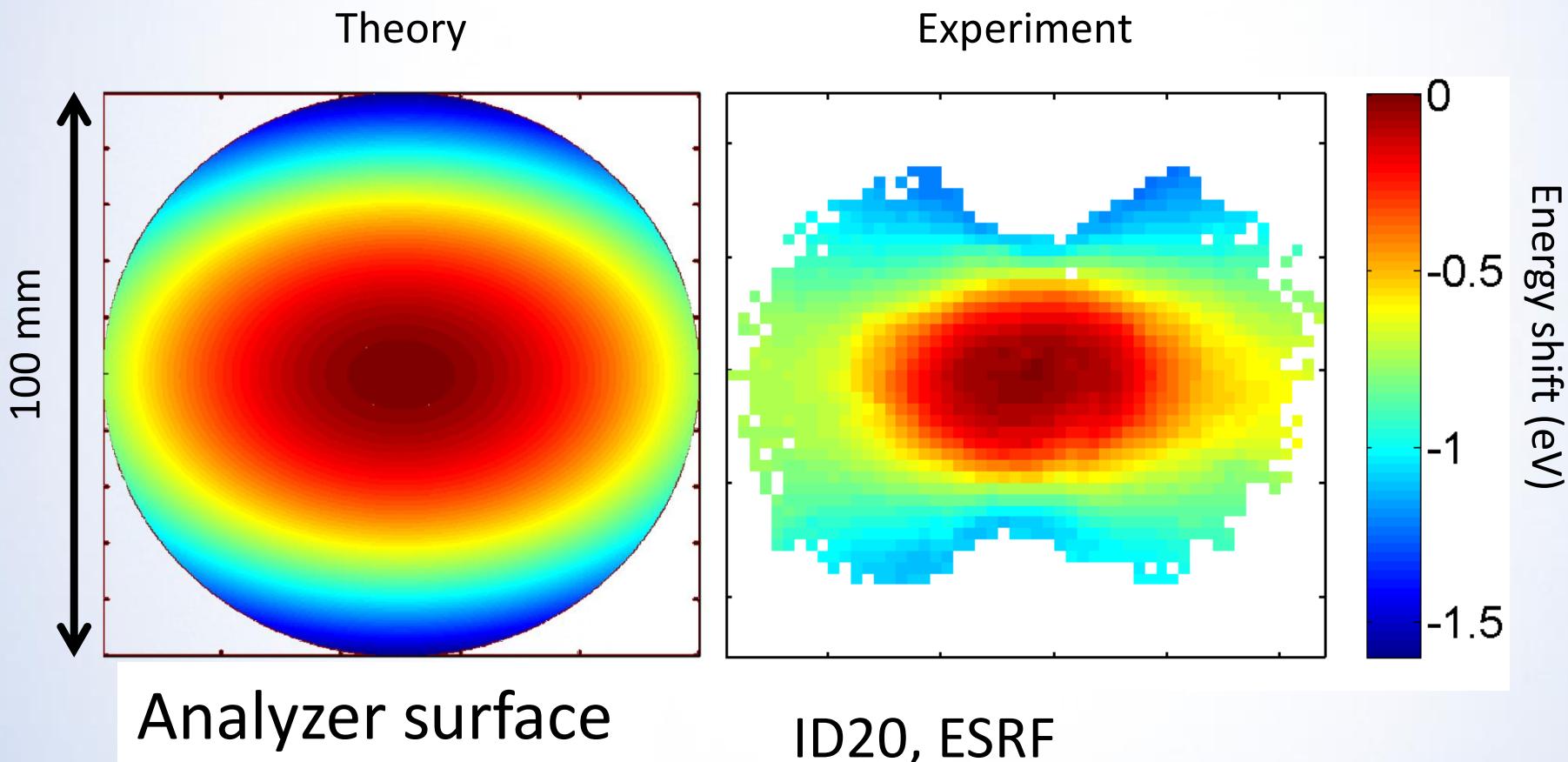
Resolution function of cut Si(660)



Ari-Pekka Honkanen et al.,  
J. Synchrotron Radiat. 11, 762 (2014)  
J. Appl. Cryst. 49, 1284 (2016)

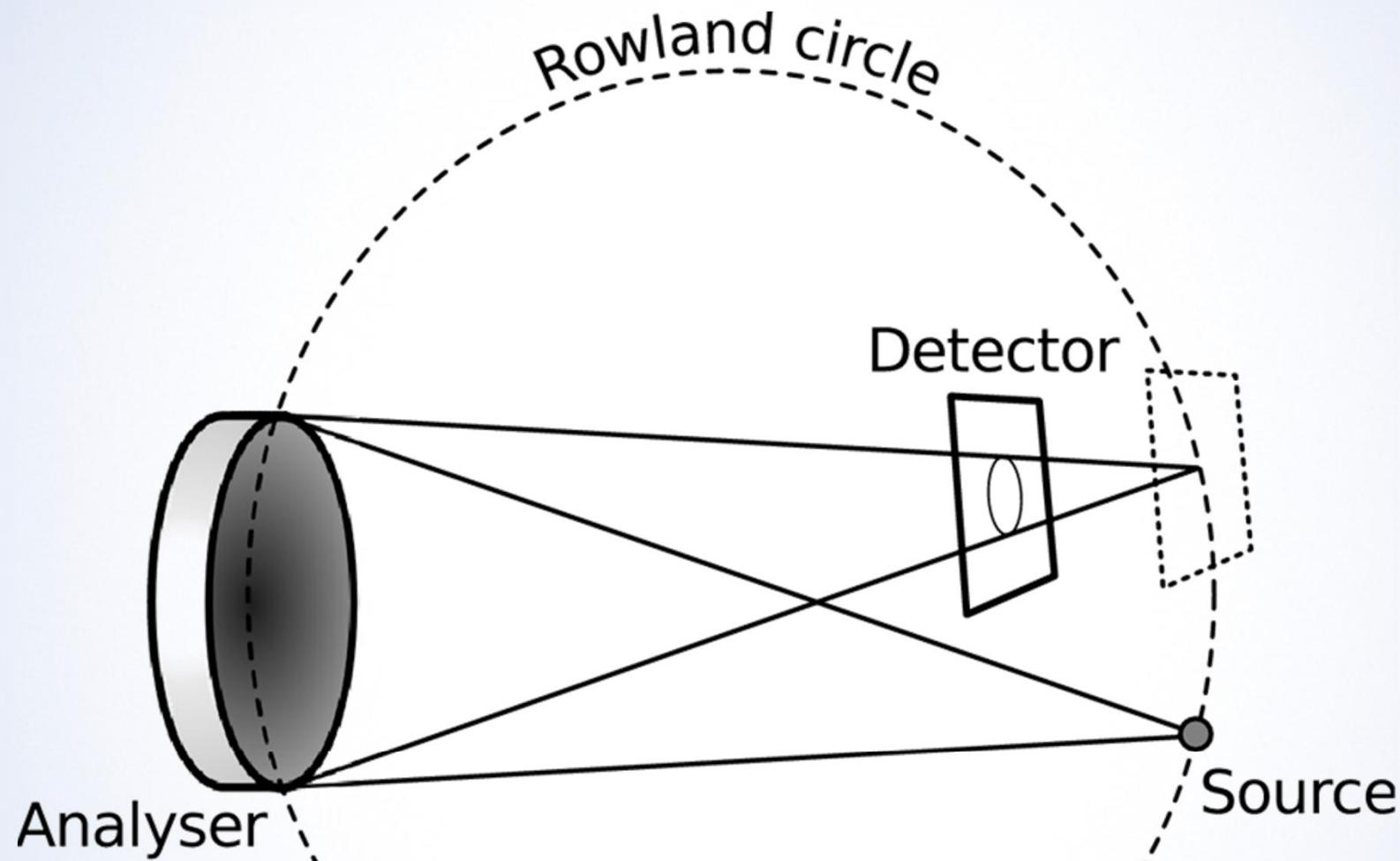
# Quantifying angular strain

Distribution of energy shifts caused by angular strain  
Si(660) in near backscattering, E=9.7 keV, R=1 m

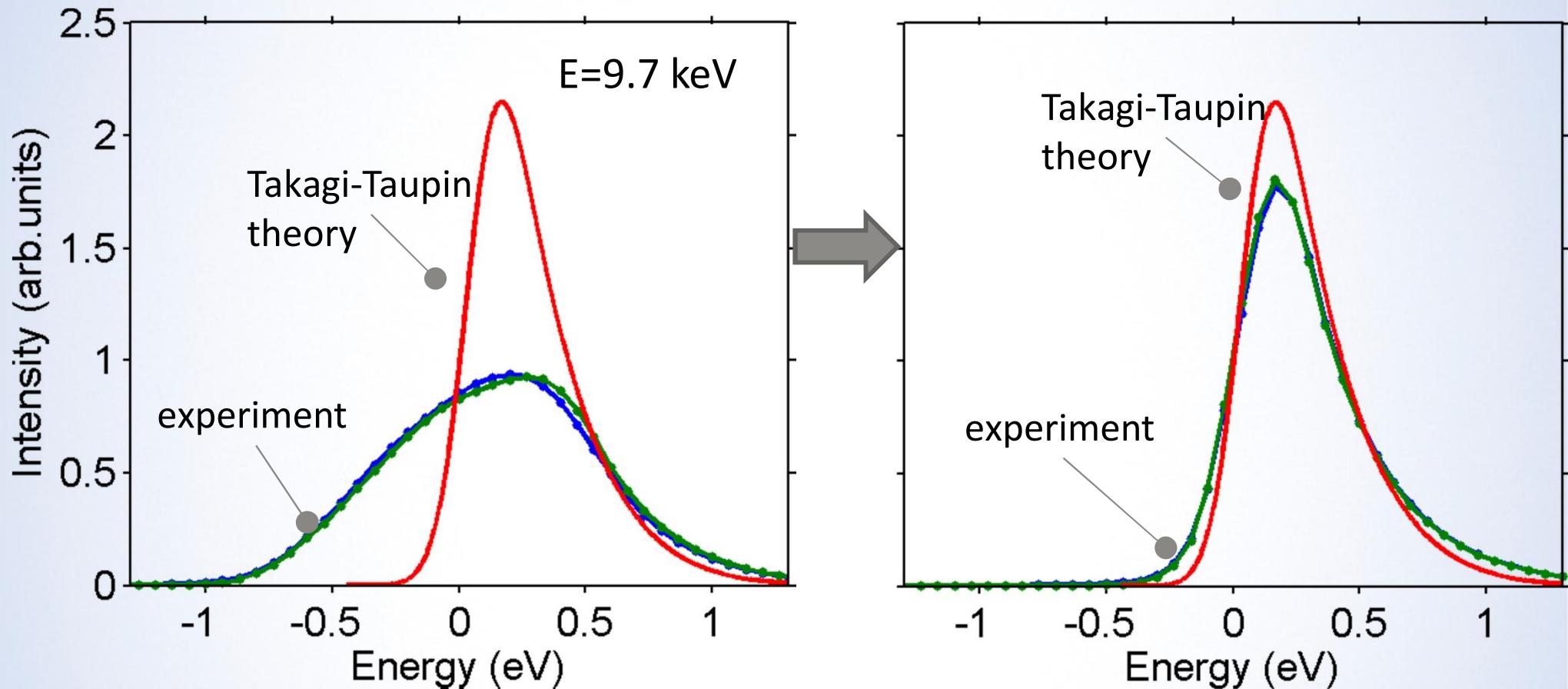


Ari-Pekka Honkanen et al., J. Synchrotron Radiat. 11, 762 (2014)  
J. Appl. Cryst. 49, 1284 (2016)

# Quantifying angular stress



# RESOLUTION FUNCTION CORRECTION

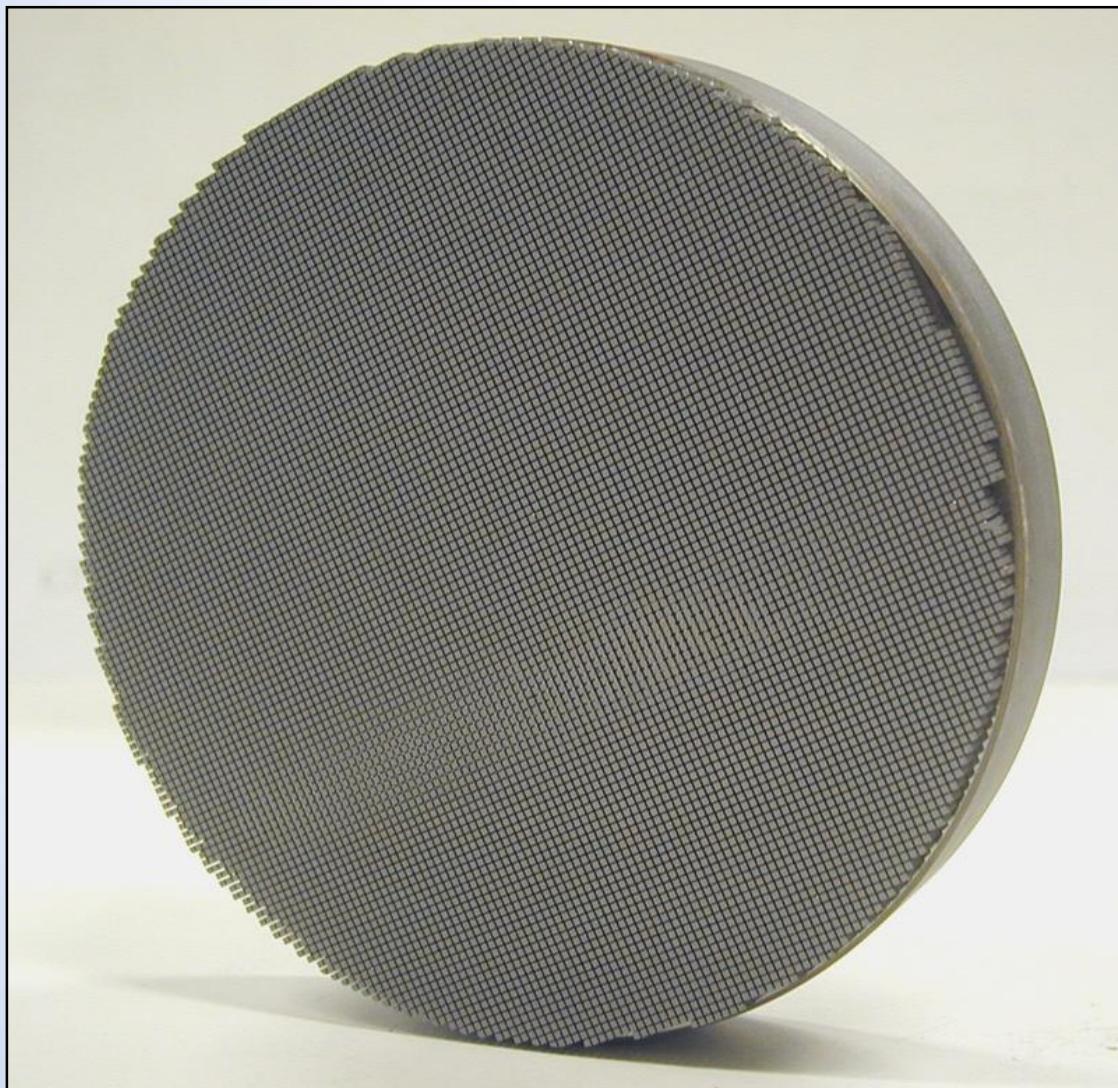


(Honkanen, pixelwise compensation method)

J. Synchr. Rad. 21, 762 (2014)

# DICED CRYSTALS

Not bent, instead: several small flat crystallites (each  $\sim\text{mm}^2$ )  
to approximate the curved surface

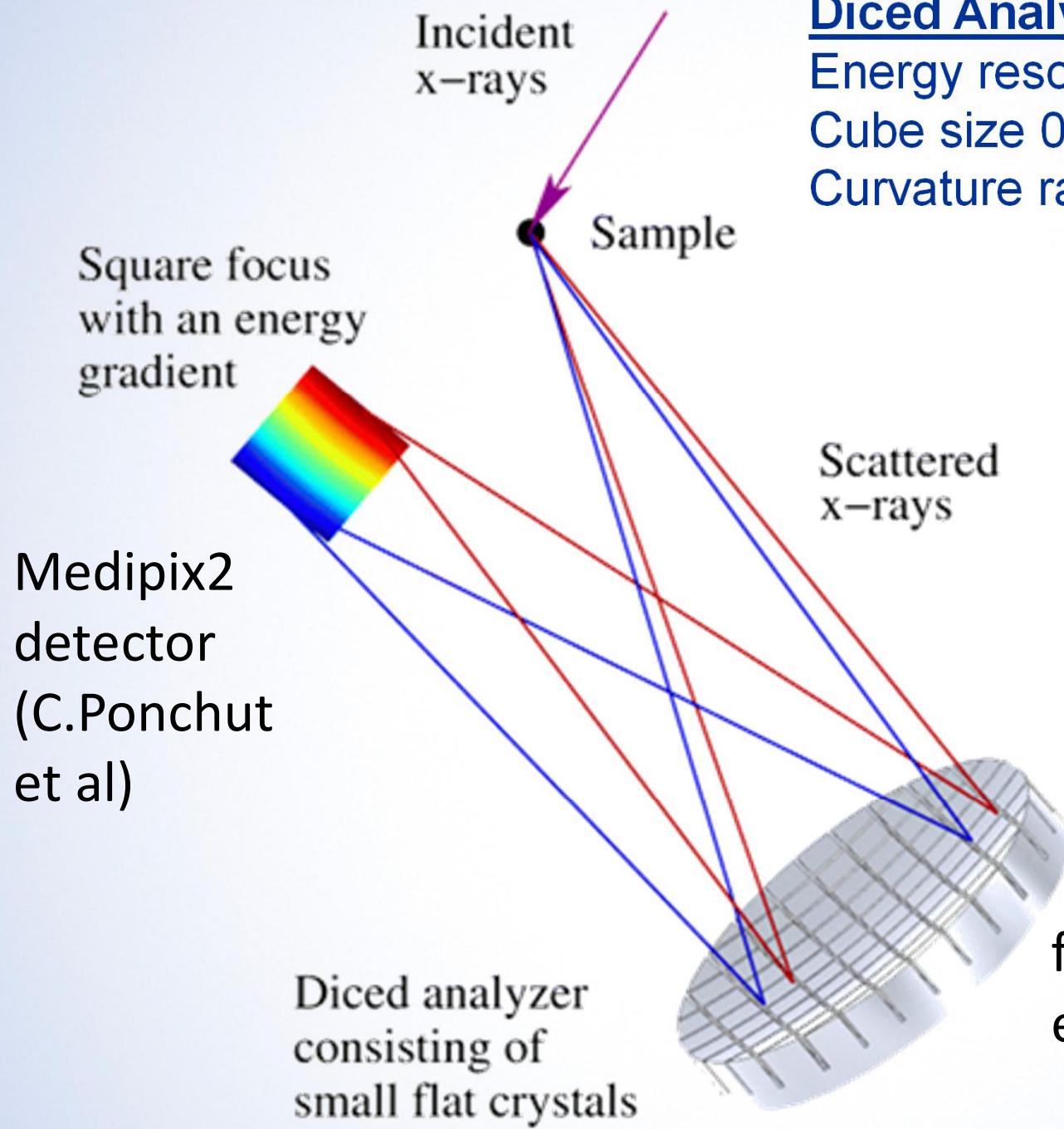


In Rowland geometry  
Energy resolution set by  
Darwin width  
FWHM  $\sim 1 \text{ meV}$  @20 keV)

Blasdell and Macrander, Rev.  
Sci. Instrum. 66, 2075 (1995)

Masciovecchio et al. Nucl.  
Instrum. Meth. B 111, 181  
(1996); Nucl. Instrum. Meth. B  
117, 339 (1996)

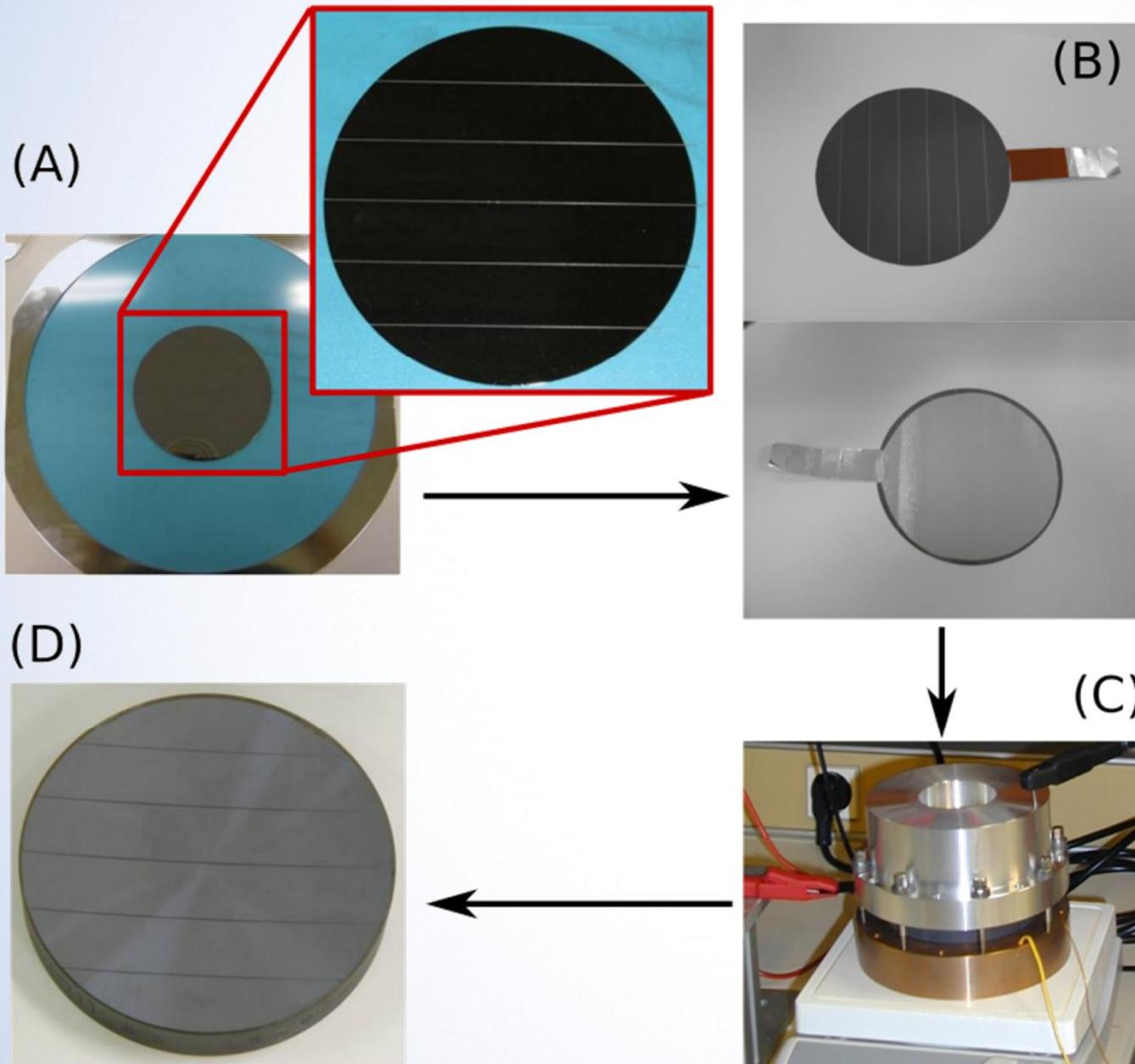
Figure: ESRF crystal analyzer lab;  
Roberto Verbeni et al.



## Diced Analyzers

Energy resolution  $\sim 1$  meV @ 20 keV  
Cube size 0.8 mm x 0.8 mm x 3 mm  
Curvature radius 1 m to  $>10$  m

# STRESS-RELIEVED CRYSTALS



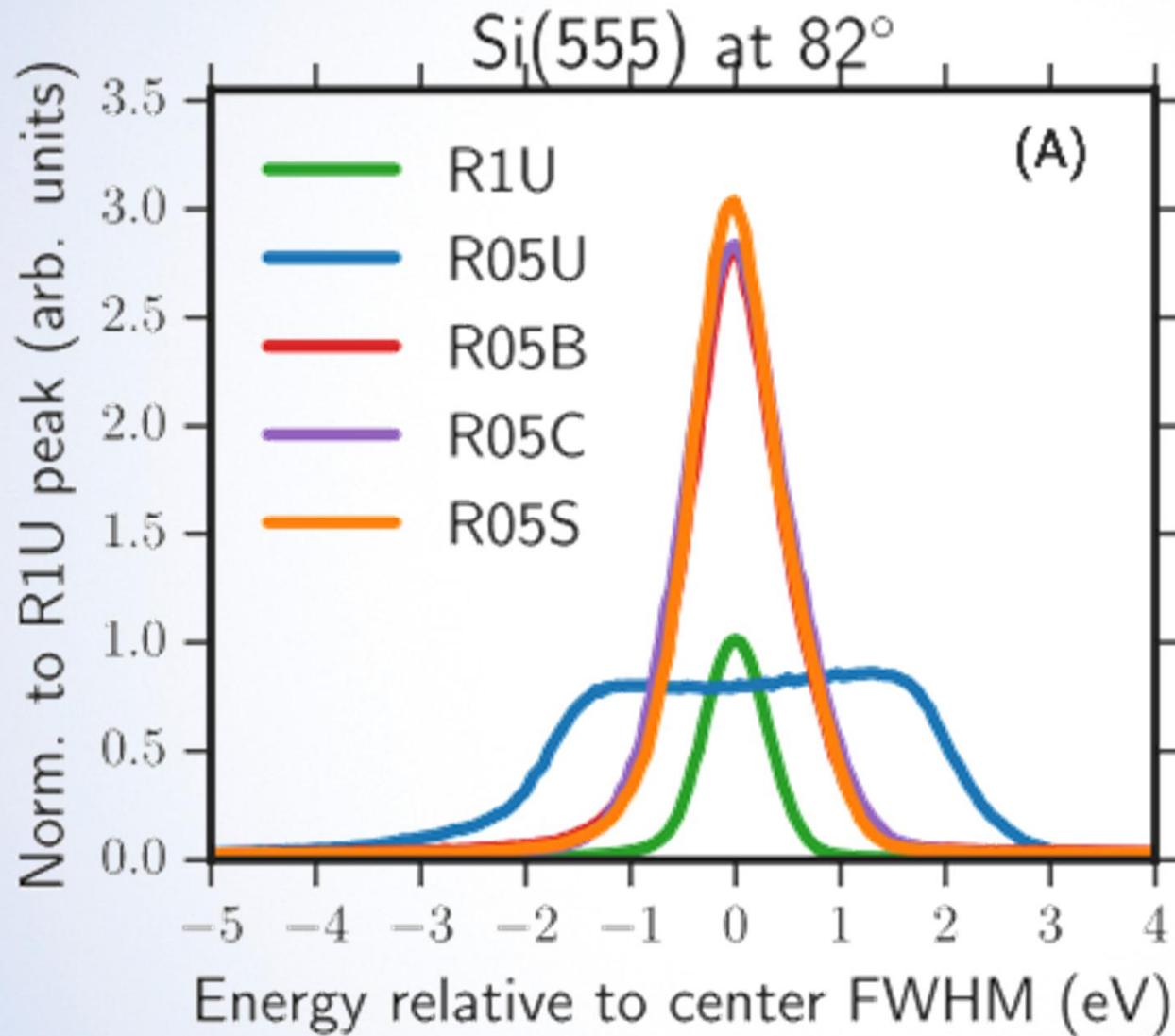
ESRF Crystal Lab

R=0.5 m  
(cf. standard  
R=1 m up to now)

150  $\mu\text{m}$  thick wafer  
cut into 15 mm slices

Rovezzi et al.,  
Review of  
Scientific  
Instruments **88**,  
013108 (2017)

# STRESS-RELIEVED CRYSTALS



Rovezzi et al.,  
Review of Scientific  
Instruments **88**,  
013108 (2017)

R=0.5 m crystals  
compared to  
R=1.0 m crystal

# Modern instruments

Cover page of Journal of Synchr.

Radiat. March 2017 :

**Huotari et al., JSR 2017**

Spectrometer located at  
**European Synchrotron  
Radiation Facility (ESRF,  
Grenoble, France)**

**Beamline ID20:**

Energy range 4-20 keV

inelastic x-ray scattering  
(resonant and non-resonant)

x-ray emission spectroscopy

high-energy-resolution  
fluorescence detected XAS



IUCr Journals | Wiley

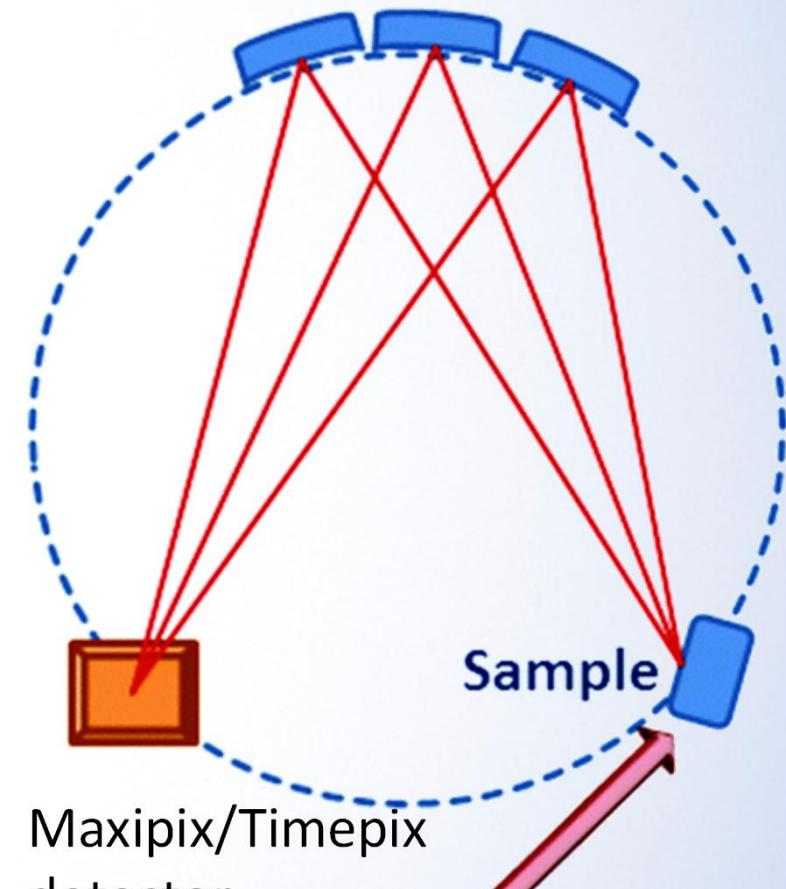
# ID20@ESRF

Roberto Verbeni and his 72 analyzers

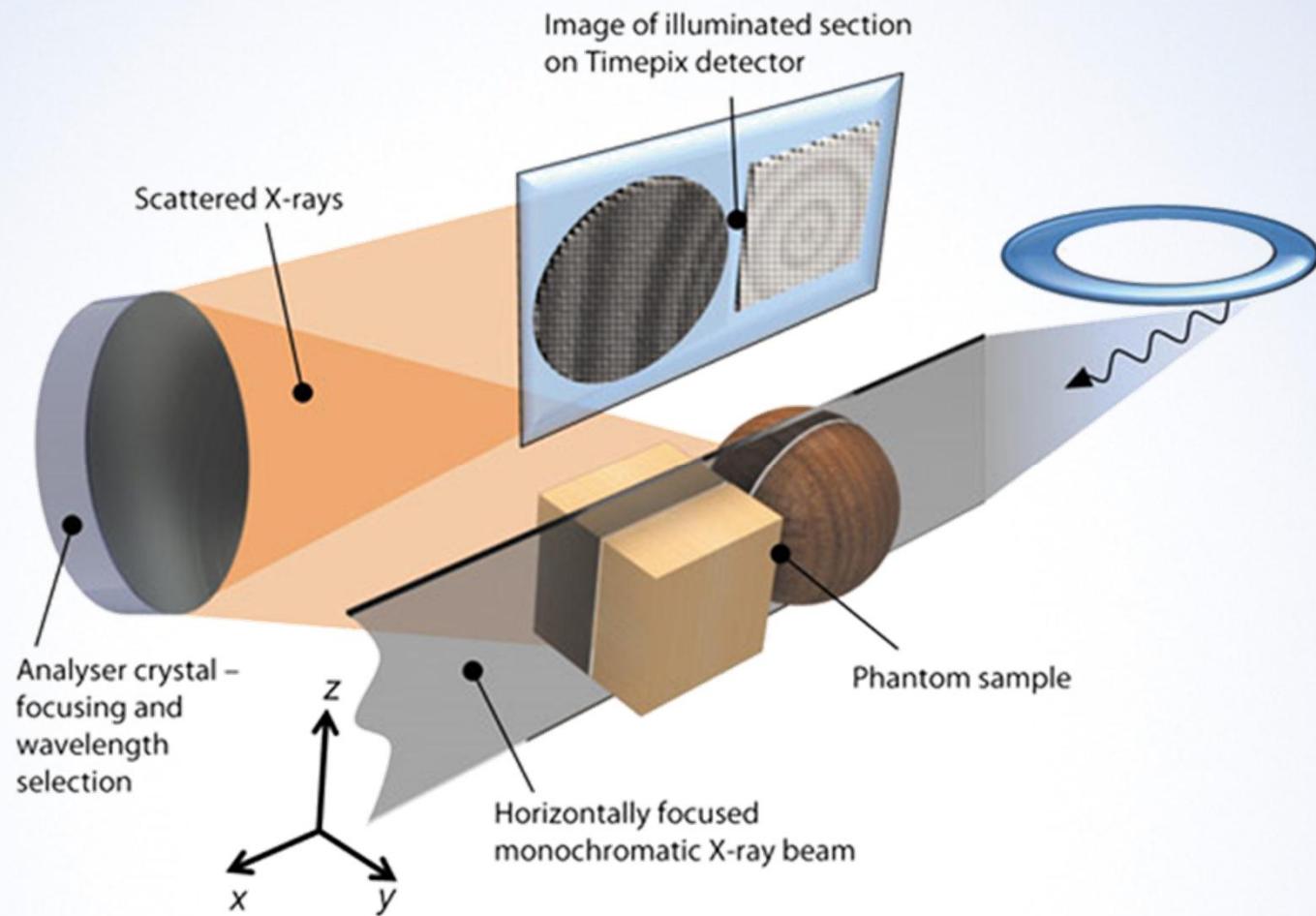


Credit: ID20 team (Laura Simonelli, M.  
Moretti Sala, Ali Al-Zein, R. Verbeni, M.  
Krisch, G. Monaco, et al.)

3 x 4 Johann spherically bent  
analyzer crystals in a module



Maxipix/Timepix  
detector  
256x256 pixels  
 $55 \times 55 \mu\text{m}^2$  each

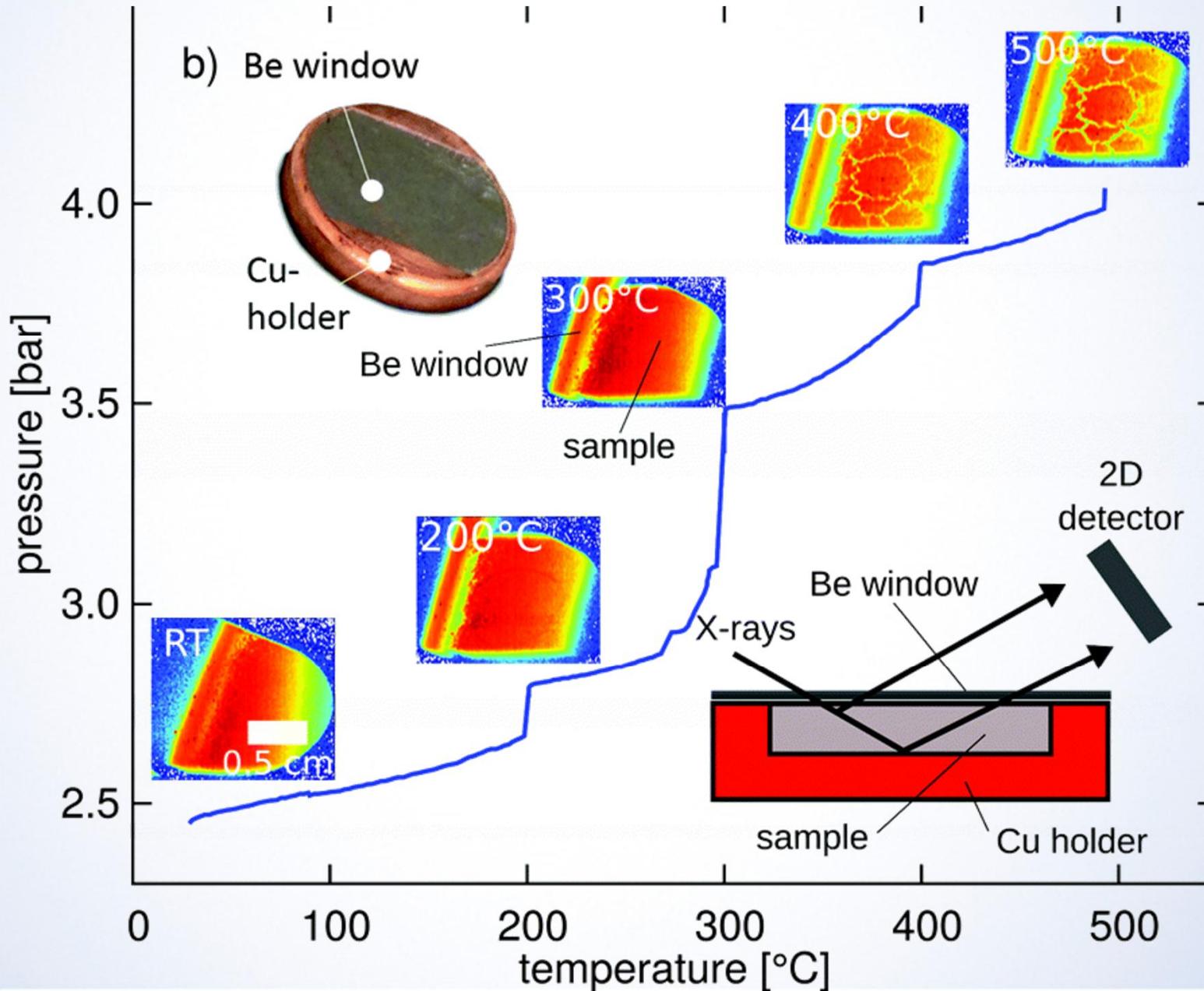


## Direct tomography with chemical-bond contrast

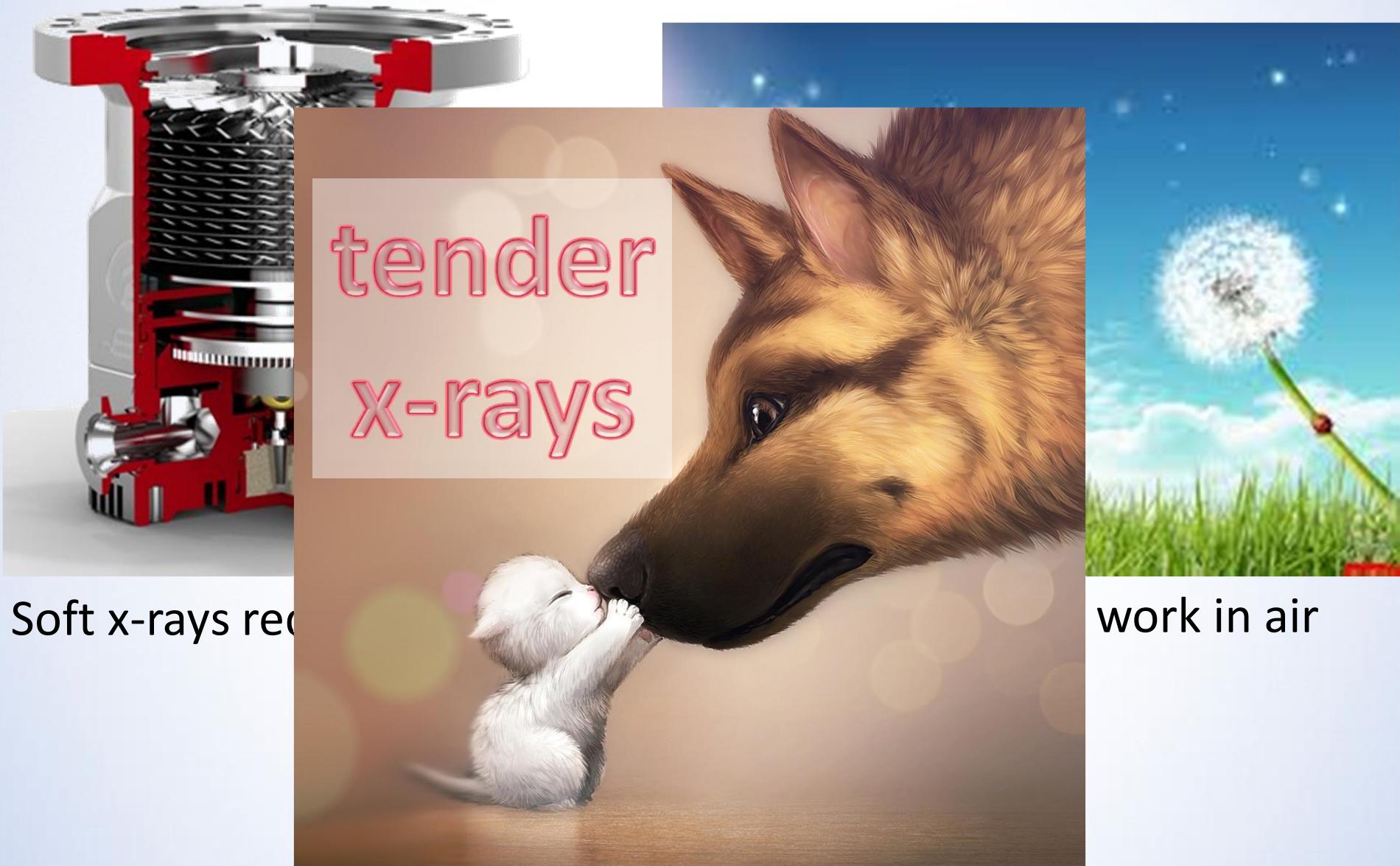
Simo Huotari<sup>1,2\*</sup>, Tuomas Pylkkänen<sup>1,2</sup>, Roberto Verbeni<sup>1</sup>, Giulio Monaco<sup>1</sup> and Keijo Hämäläinen<sup>2</sup>

# IMAGING/SPECTROSCOPY WITH 2D DETECTOR + CRYSTAL OPTICS

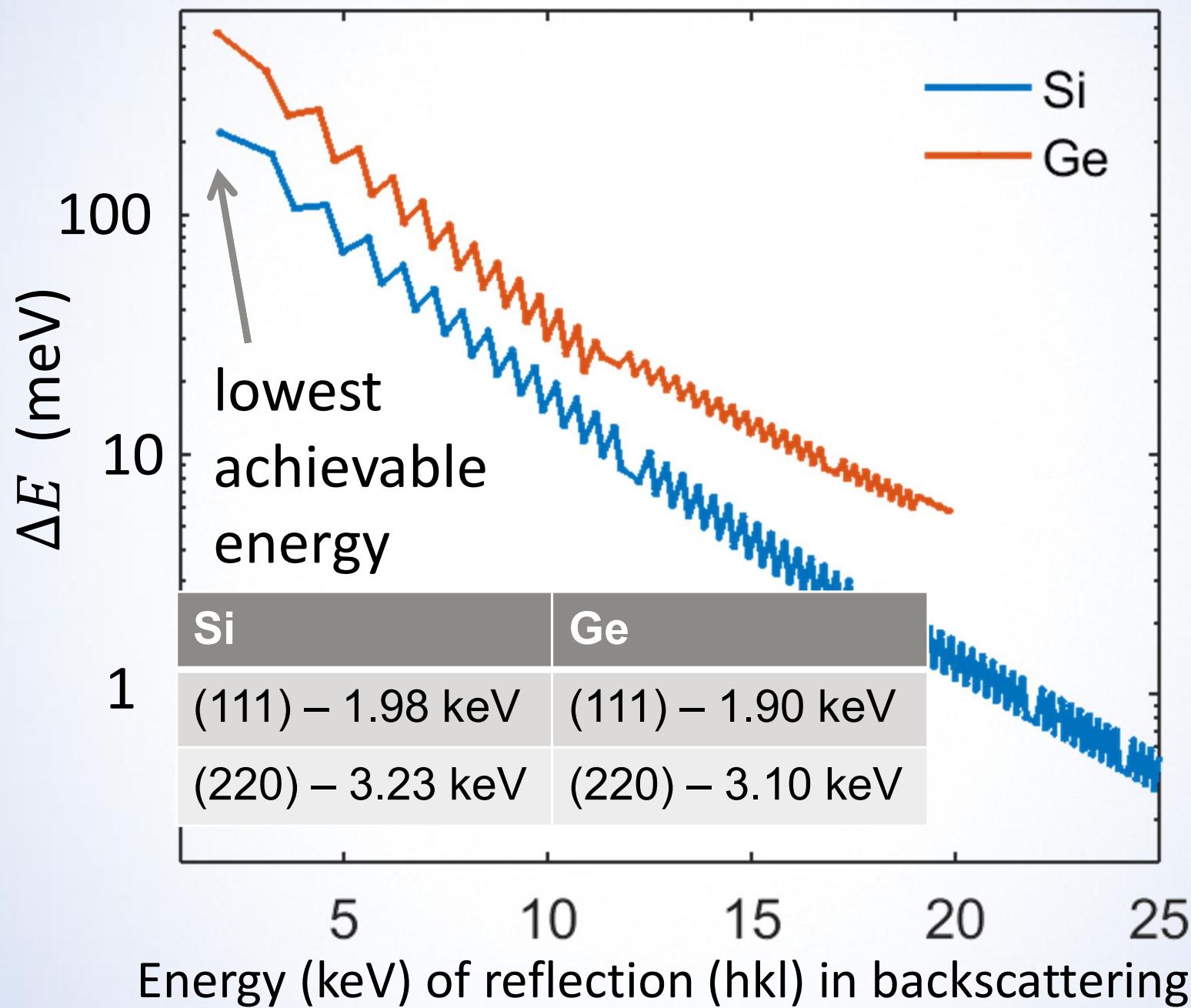
Ch. Sahle et al., PCCP 18, 5397 (2016)



# SOFT – TENDER – HARD X-RAYS

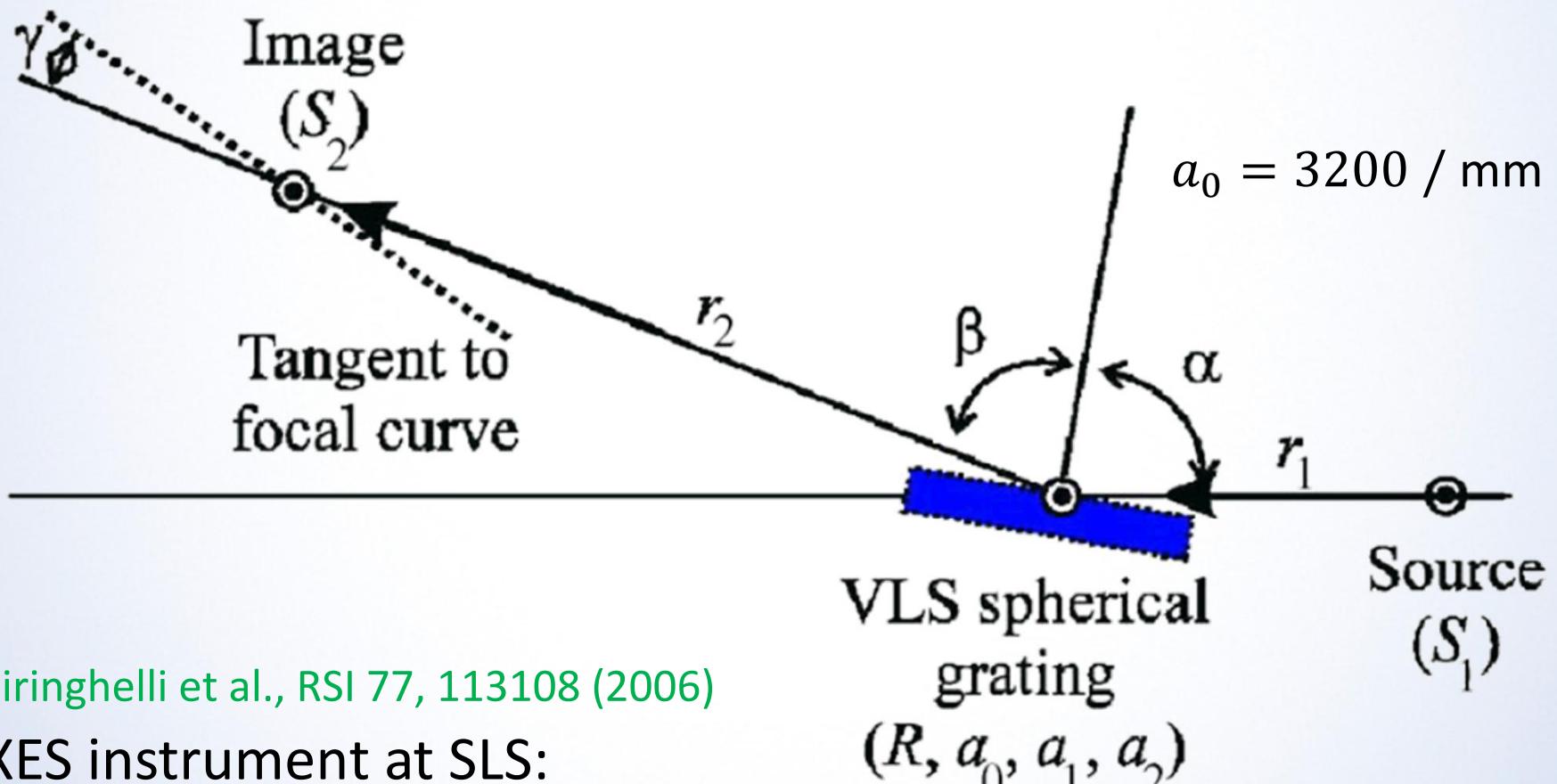


# ULTIMATE ENERGY RESOLUTION BY DARWIN WIDTH



# SOFT X-RAY SPECTROMETERS

- Natural crystals (Bragg) are not an option
- Grazing incidence concave diffraction gratings with variable line spacing (VLS)



G. Ghiringhelli et al., RSI 77, 113108 (2006)

SAXES instrument at SLS:

400-1100 eV,  $E/\Delta E \approx 10000$

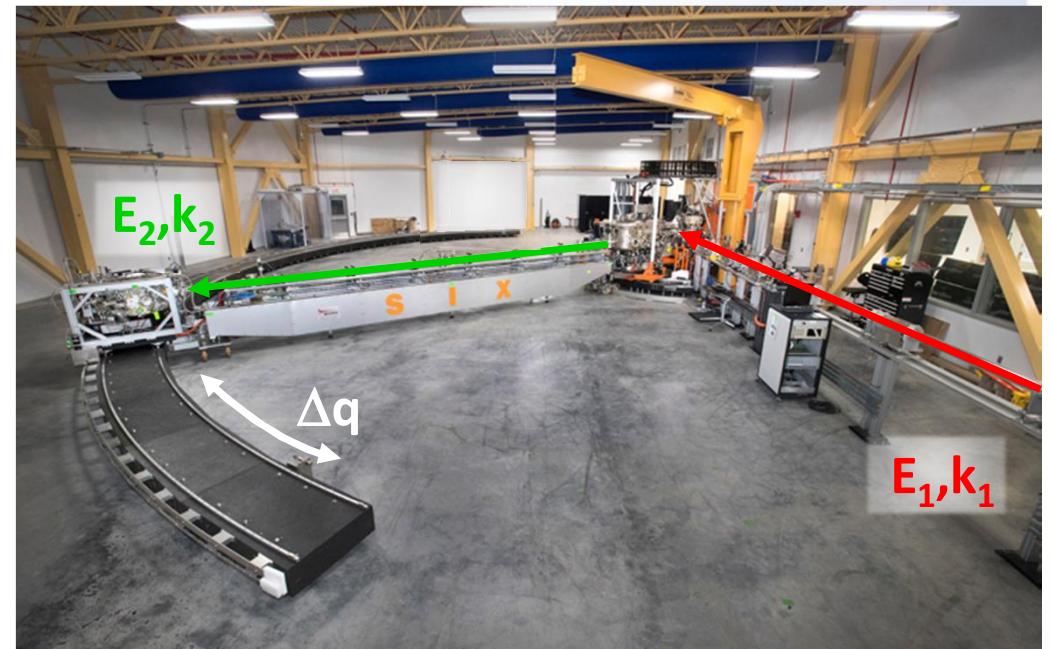
$$(R, a_0, a_1, a_2)$$

$$a(x) = a_0 + a_1x + a_2x^2 + a_3x^3 + \dots$$

# SOFT INELASTIC X-RAY SCATTERING (SIX) AT NSLS-II

Resonant inelastic x-ray scattering at an unprecedented energy resolution for unrivaled sensitivity to low-energy collective excitations.

- 135-2300 eV energy range with  $0.6 \mu\text{m}$  (V) x  $6 \mu\text{m}$  (H) focus
- Resolving power up to 100,000
- Moving 15-m long arm for unbroken access to full range of momentum transfers
- Sample cooling to  $\sim 15$  K



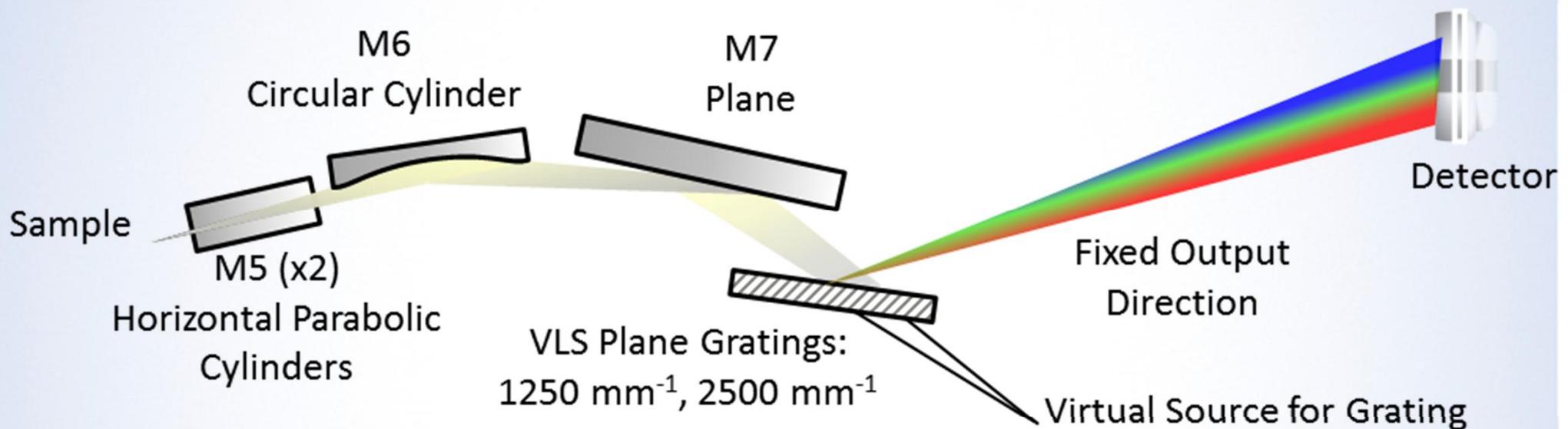
Goal:  $\Delta E = 15 \text{ meV}$  at 1,000 eV

First light: Feb. 21<sup>st</sup> 2017

Slide courtesy from NSLS-II / Ignace Jarrige, Joe Dvorak et al.  
shared for this occasion

# SIX OPTICAL DESIGN

Slide courtesy from NSLS-II / Ignace Jarrige et al.



- **M5:** Horizontally collimating mirrors located close to sample for large solid angle
- **M6:** Vertical focusing mirror for virtual source for grating
- **M7:** Vertical deflecting mirror ⇒ beam outgoing angle constant

Slide courtesy from NSLS-II / Ignace Jarrige, Joe Dvorak et al.  
shared for this occasion

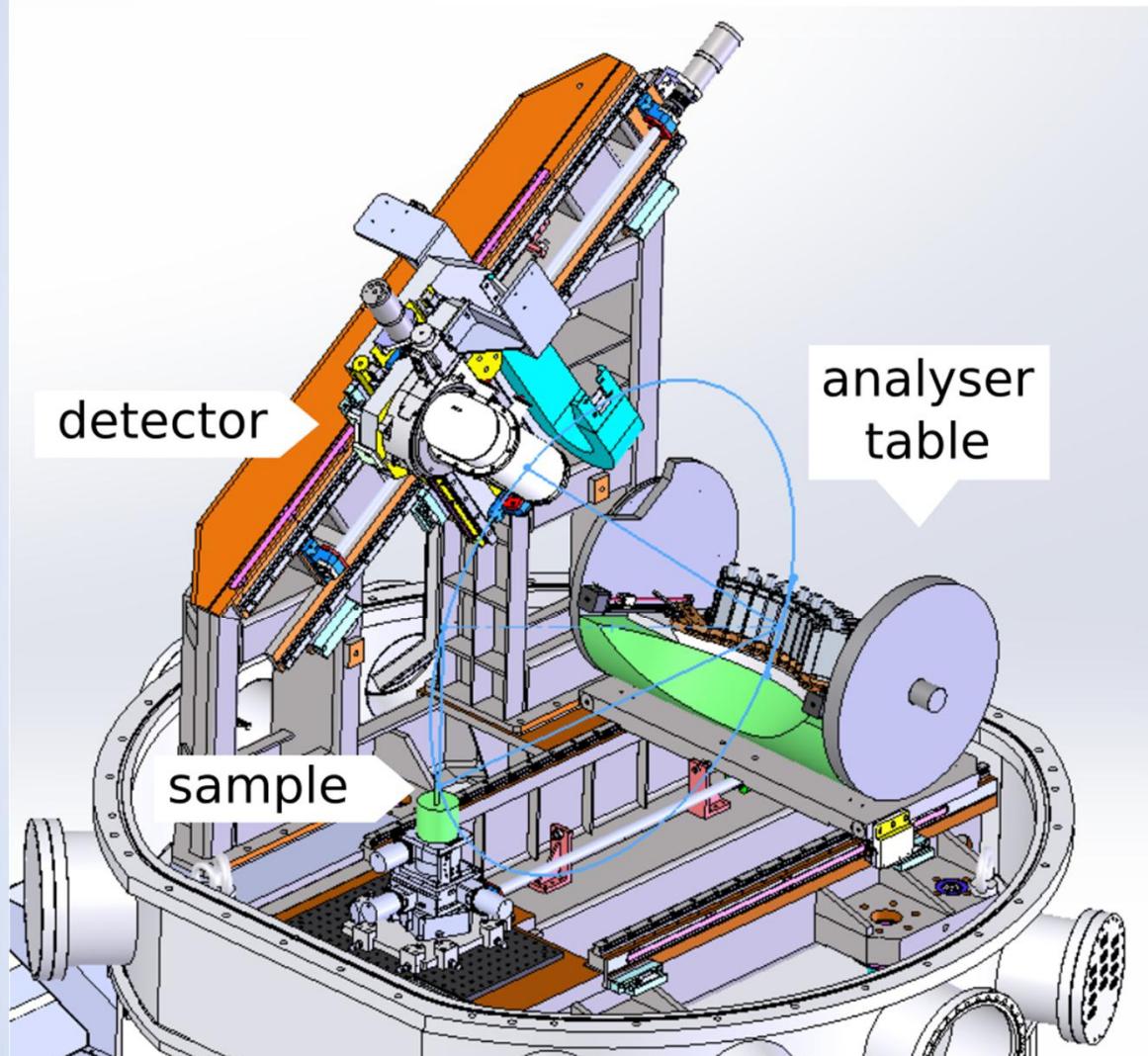
# SIX SPECTROMETER @ NSLS-II



Slide courtesy from NSLS-II / Ignace Jarrige, Joe Dvorak et al.  
shared for this occasion

# Large area in-vacuum detector for XES, ESRF ID26

M. Kocsis, M. Rovezzi, B. Detlefs, P. Glatzel, ESRF

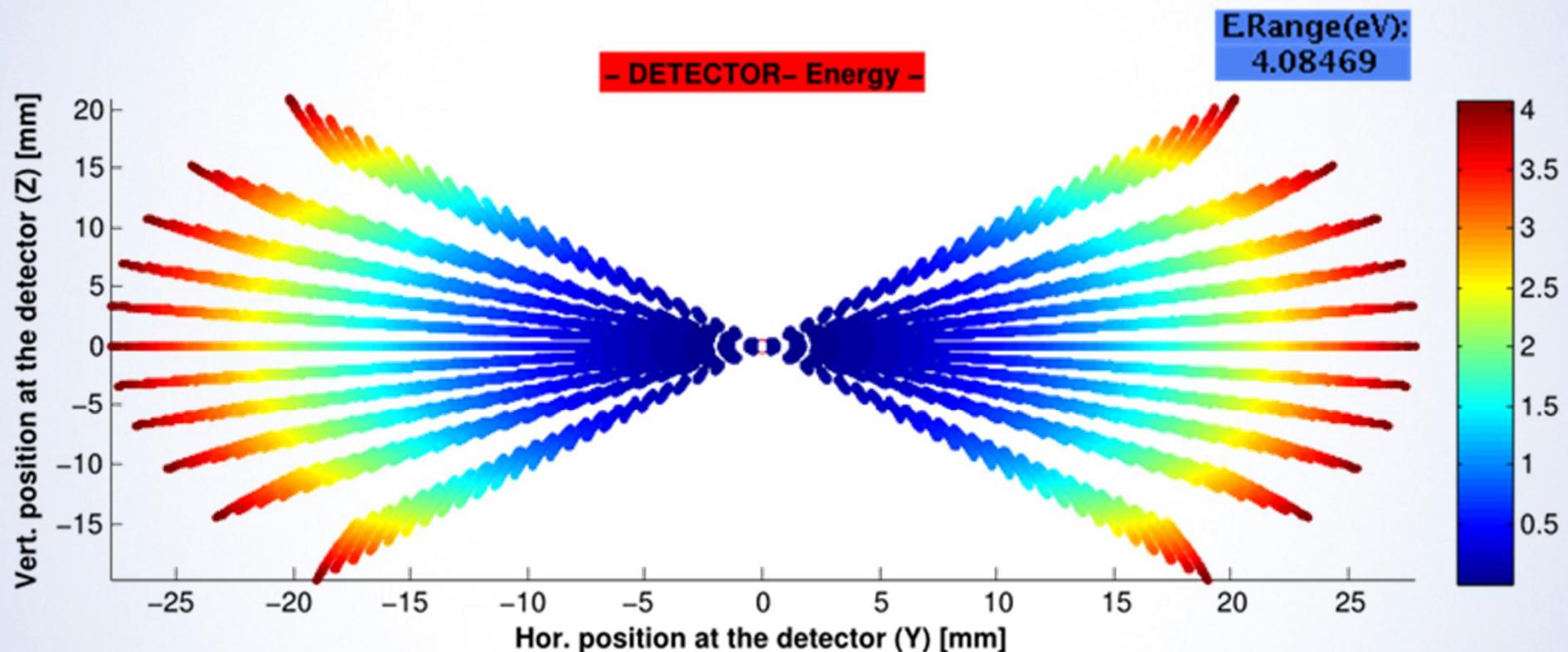


- Energy 1.5—5.5 keV; very low electronic noise, high quantum efficiency (>80%)
- No suitable detector on the market → Inhouse
- 16 vertical wires gas flow proportional counter detector
- Gas: 15% CO<sub>2</sub> in Ar
- Vacuum compatibility: flexible hoses (inverse vacuum), thin polymer entrance window

Slide courtesy from ESRF / Pieter Glatzel et al., shared for this occasion

M. Kocsis, M. Rovezzi, B. Detlefs, P. Glatzel, ESRF

Detector area at  $35^\circ/500$  mm bending radius  $\cong 50 \times 40 \text{ mm}^2$



Slide courtesy from ESRF / Pieter Glatzel et al.,  
shared for this occasion

# THANK YOU!

## Slides of spectrometers around the world:

**NSLS-II (SIX):** Ignace Jarrige, Joe Dvorak, SIX team

**EuXFEL (FXE):** Christian Bressler, XFEL team

**ID26** in-vacuum spectrometer: Pieter Glatzel, M. Kocsis, B. Detlefs, M. Rovezzi, ID26/ESRF team

**ID20:** R. Verbeni, M. Moretti Sala, Ch. Sahle, L. Simonelli, C. Henriet, M. Krisch, G. Monaco, ID20/ESRF

## Team in Helsinki:

Ari-Pekka Honkanen, Rene Bes, Taru Ahopelto, Sami Ollikkala, et al.